

(12) **United States Patent**  
**Poniatowski**

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(54) **DESKTOP WORKSPACE THAT ADJUSTS VERTICALLY**

2021/0364; A47B 2021/0335; A47B 3/00;  
A47B 61/00; A47B 3/02; A47B 3/0809;  
A47B 3/0815; A47B 2003/025

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(\*) Notice: Subject to any disclaimer, the term of this patent is extended or adjusted under 35 U.S.C. 154(b) by 0 days.

This patent is subject to a terminal disclaimer.

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(51) **Int. Cl.**  
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**A47B 21/02** (2006.01)  
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CPC ..... **A47B 9/16** (2013.01); **A47B 21/02** (2013.01); **A47B 21/0314** (2013.01); **A47B 21/04** (2013.01); **A47B 2021/0335** (2013.01)

(58) **Field of Classification Search**  
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**ABSTRACT**

A desktop workspace that adjusts vertically includes a work surface platform, a base configured to sit on an existing platform, such as a desk, a height adjustable mechanism including at least one set of arms that connect at a pivot point(s) creating a scissoring motion to raise and lower the said work surface platform to various heights. A locking and unlocking mechanism may connect to the height adjustable mechanism. In some cases, the apparatus includes an adjustable mechanism to support items such as a keyboard. In some cases, the apparatus includes elements to raise items such as a monitor to an additional height.

**18 Claims, 28 Drawing Sheets**

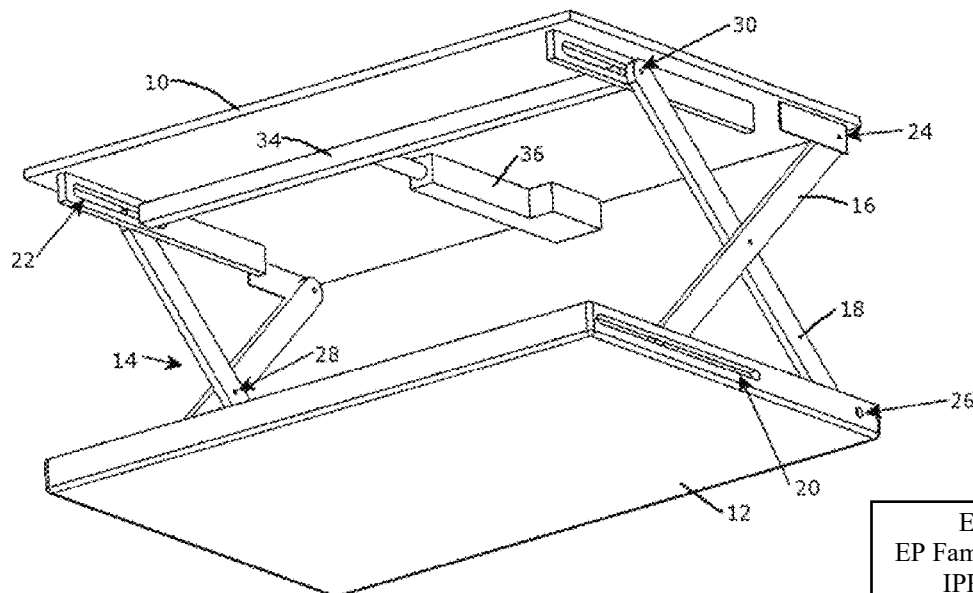


Exhibit 2004  
EP Family v Office Kick  
IPR2025-00497

**Related U.S. Application Data**

No. 17/985,137, filed on Nov. 10, 2022, now Pat. No. 11,910,926, which is a continuation of application No. 17/493,812, filed on Oct. 4, 2021, now Pat. No. 11,944,196, which is a continuation of application No. 16/785,647, filed on Feb. 9, 2020, now Pat. No. 11,134,773, which is a continuation of application No. 16/372,334, filed on Apr. 1, 2019, now Pat. No. 10,575,630, which is a division of application No. 15/628,558, filed on Jun. 20, 2017, now Pat. No. 10,244,861, which is a division of application No. 15/004,926, filed on Jan. 23, 2016, now abandoned.

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See application file for complete search history.

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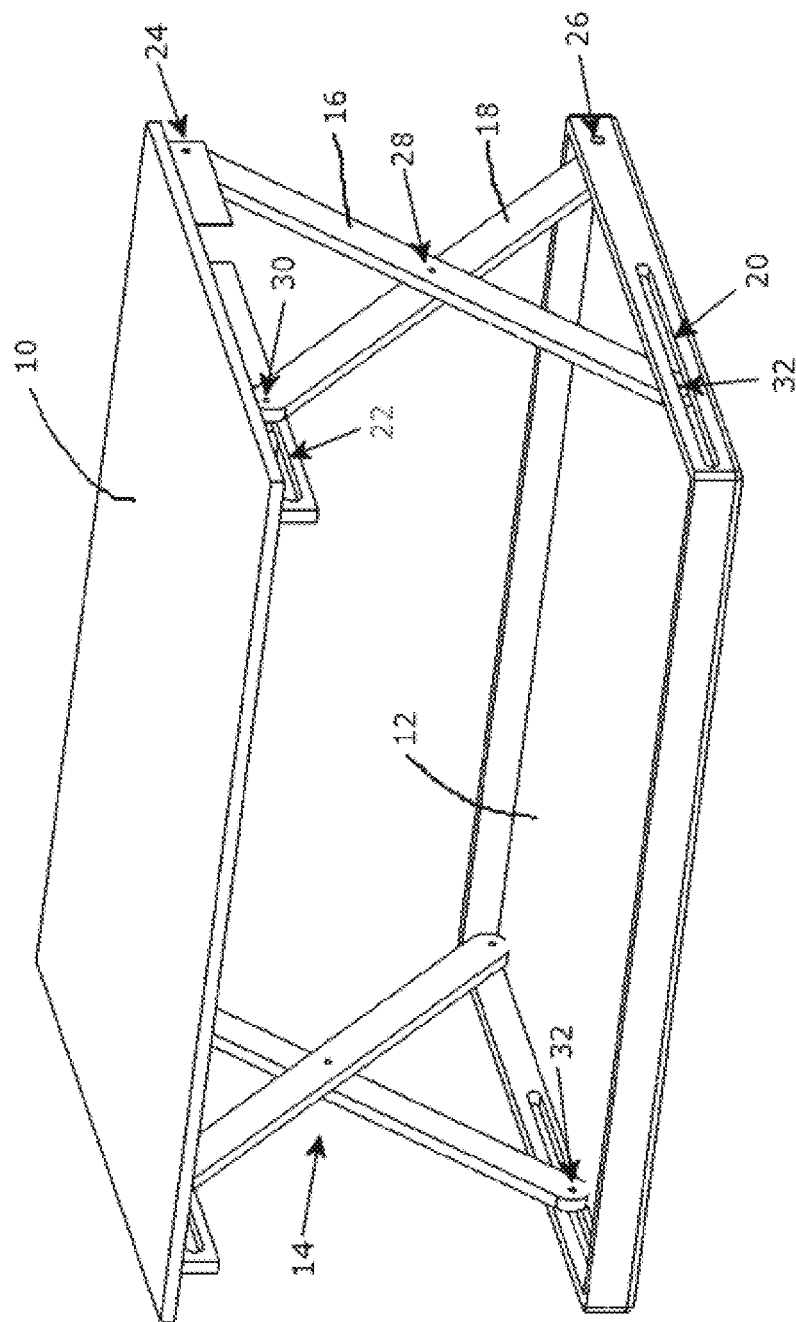


FIG. 1

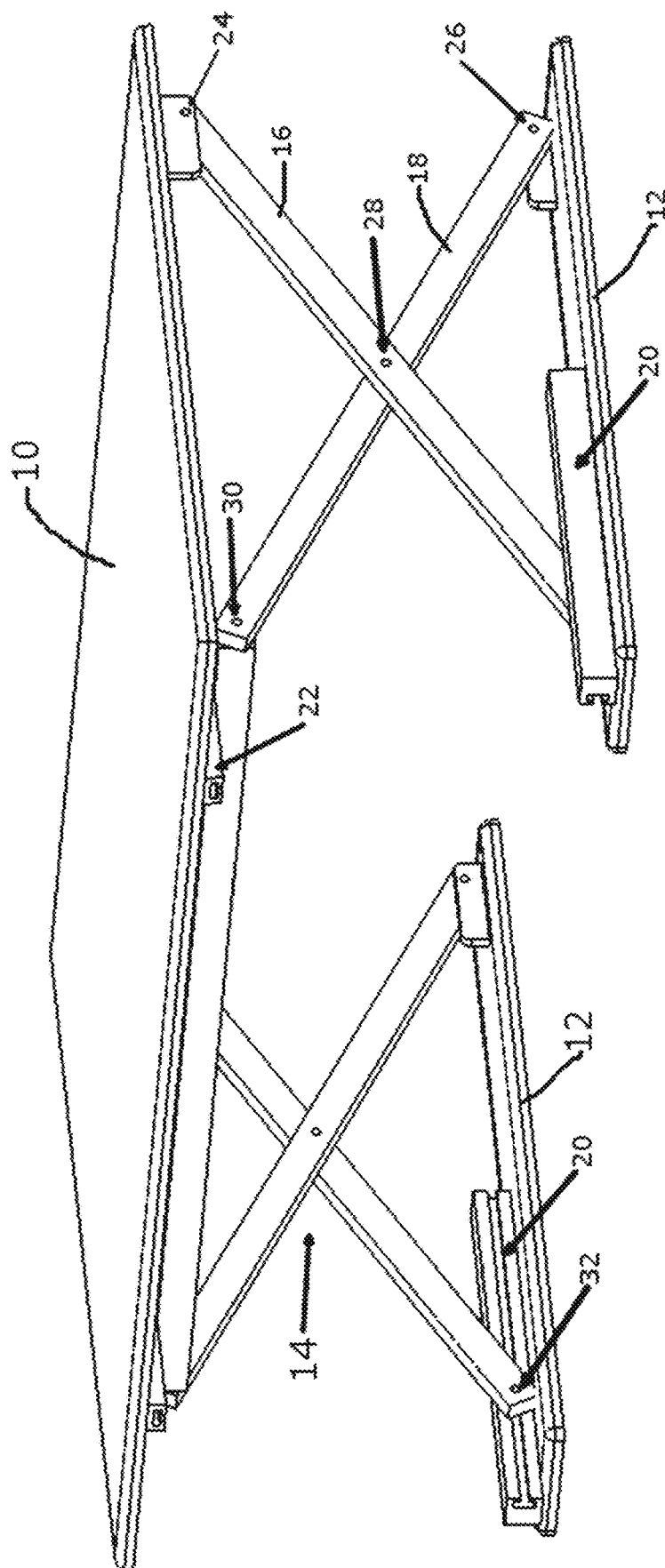


FIG. 1B

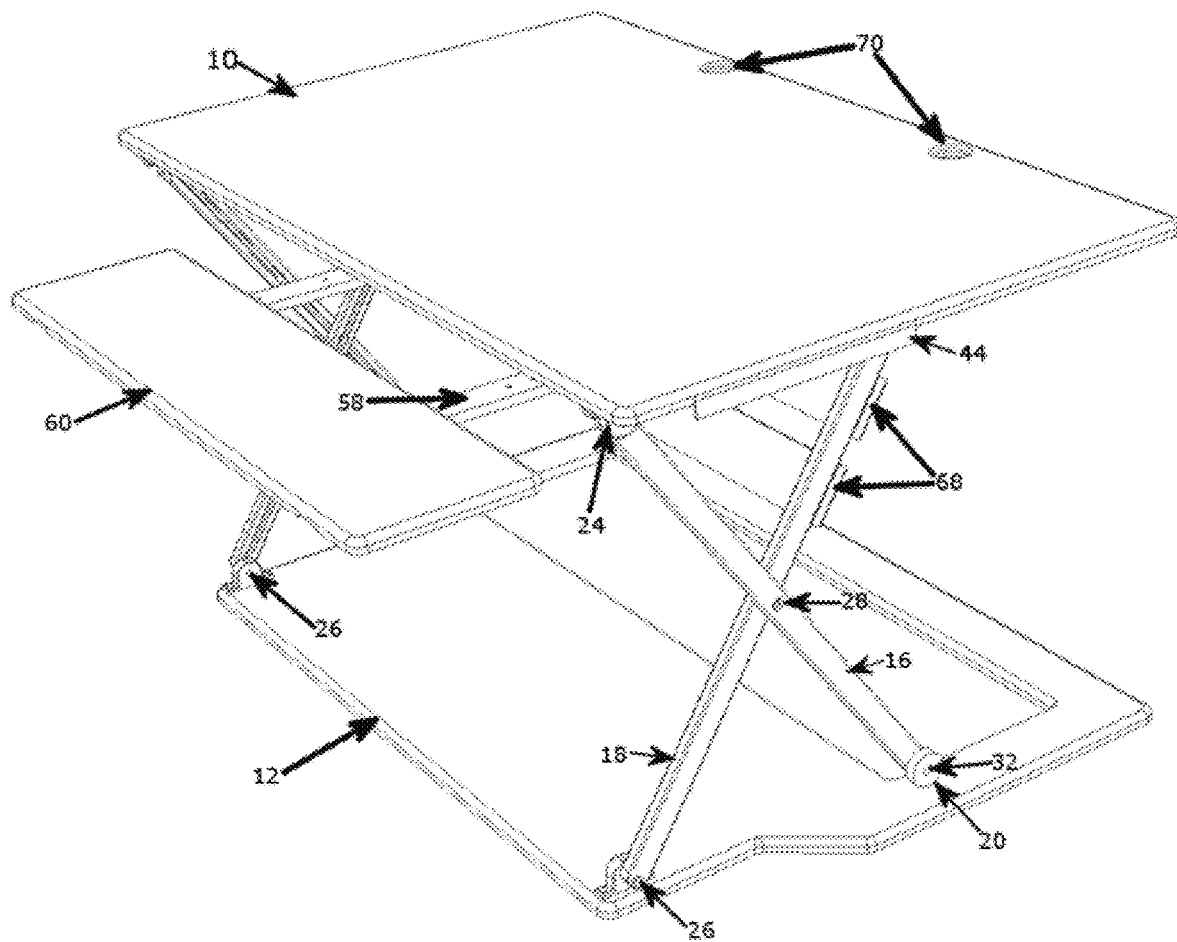


FIG. 1C

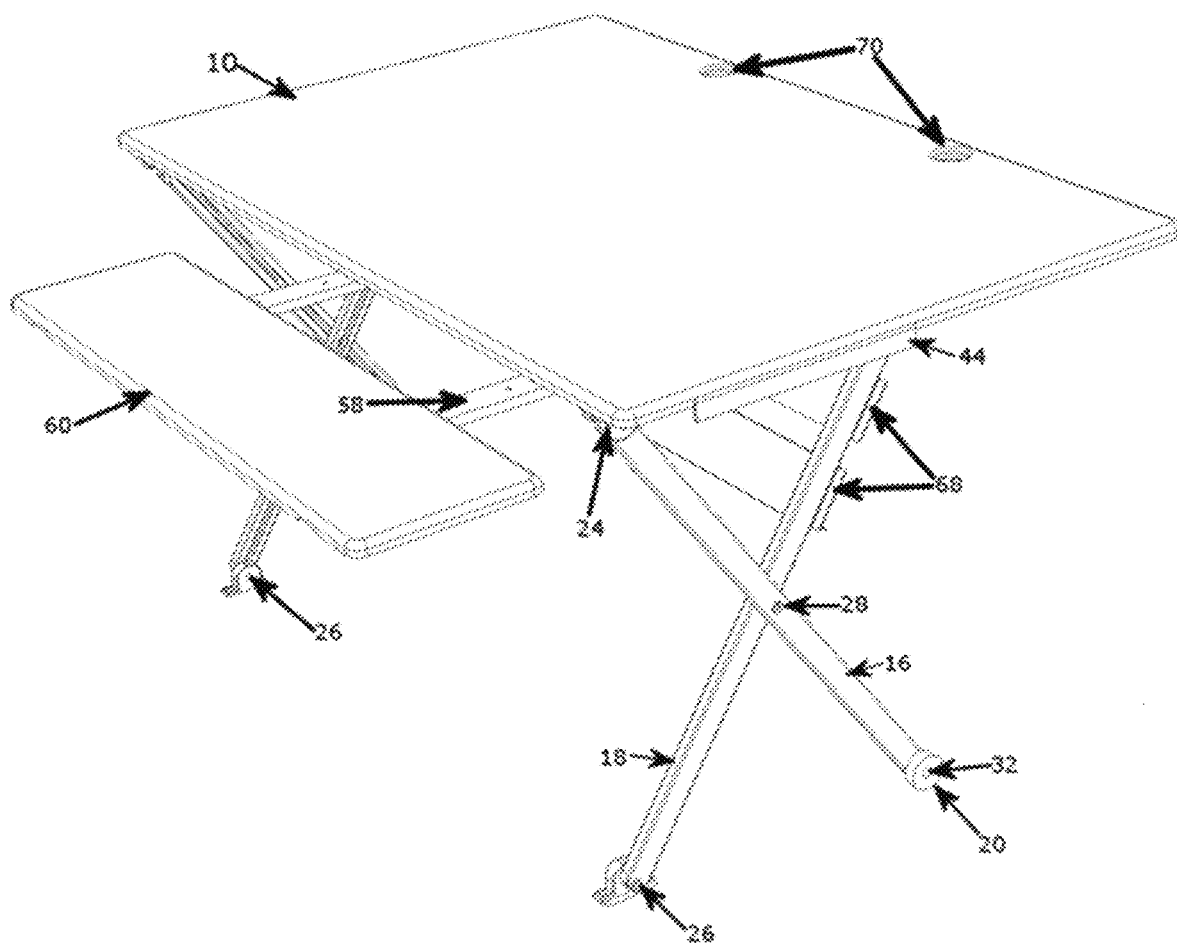


FIG. 1D

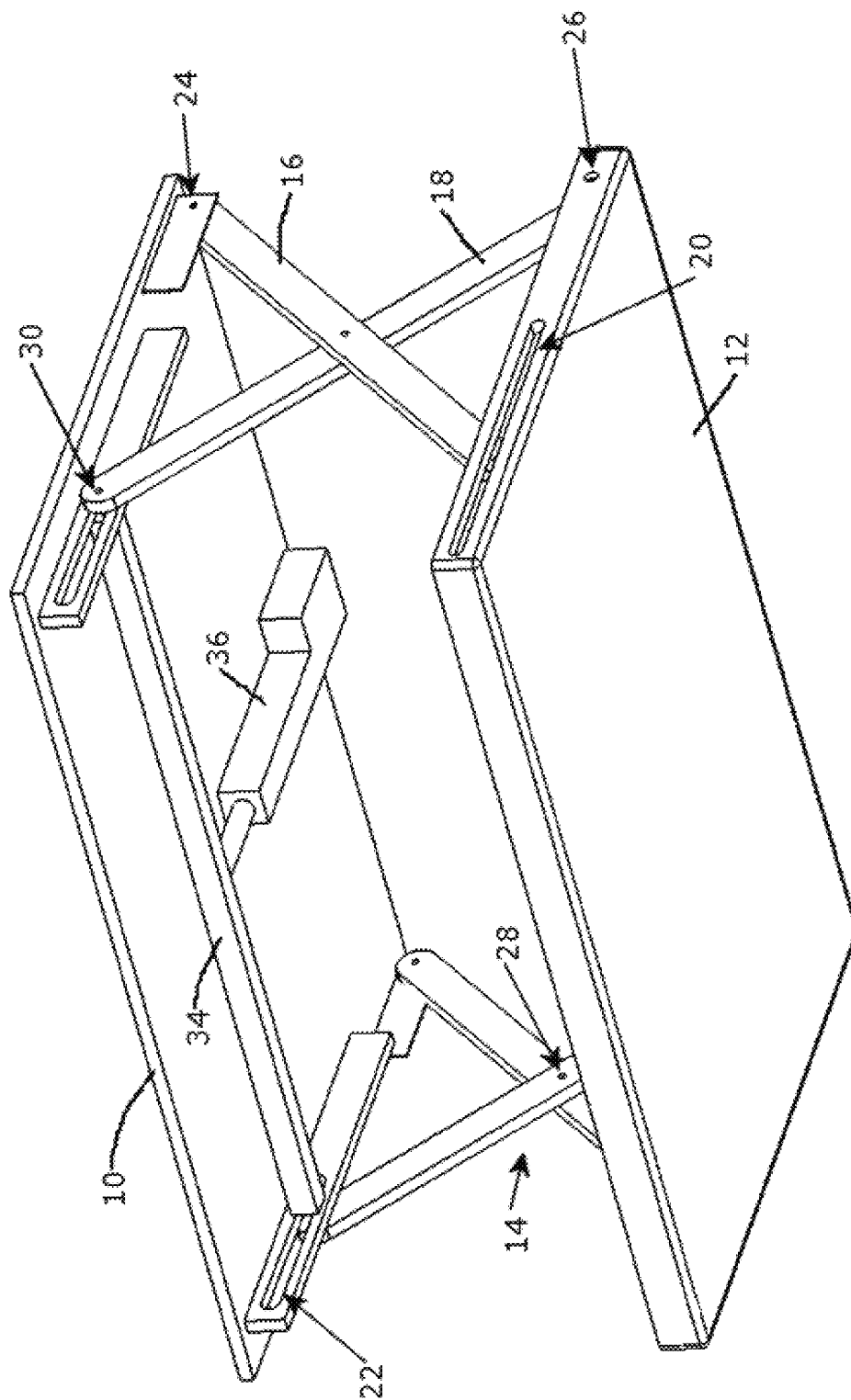


FIG. 2

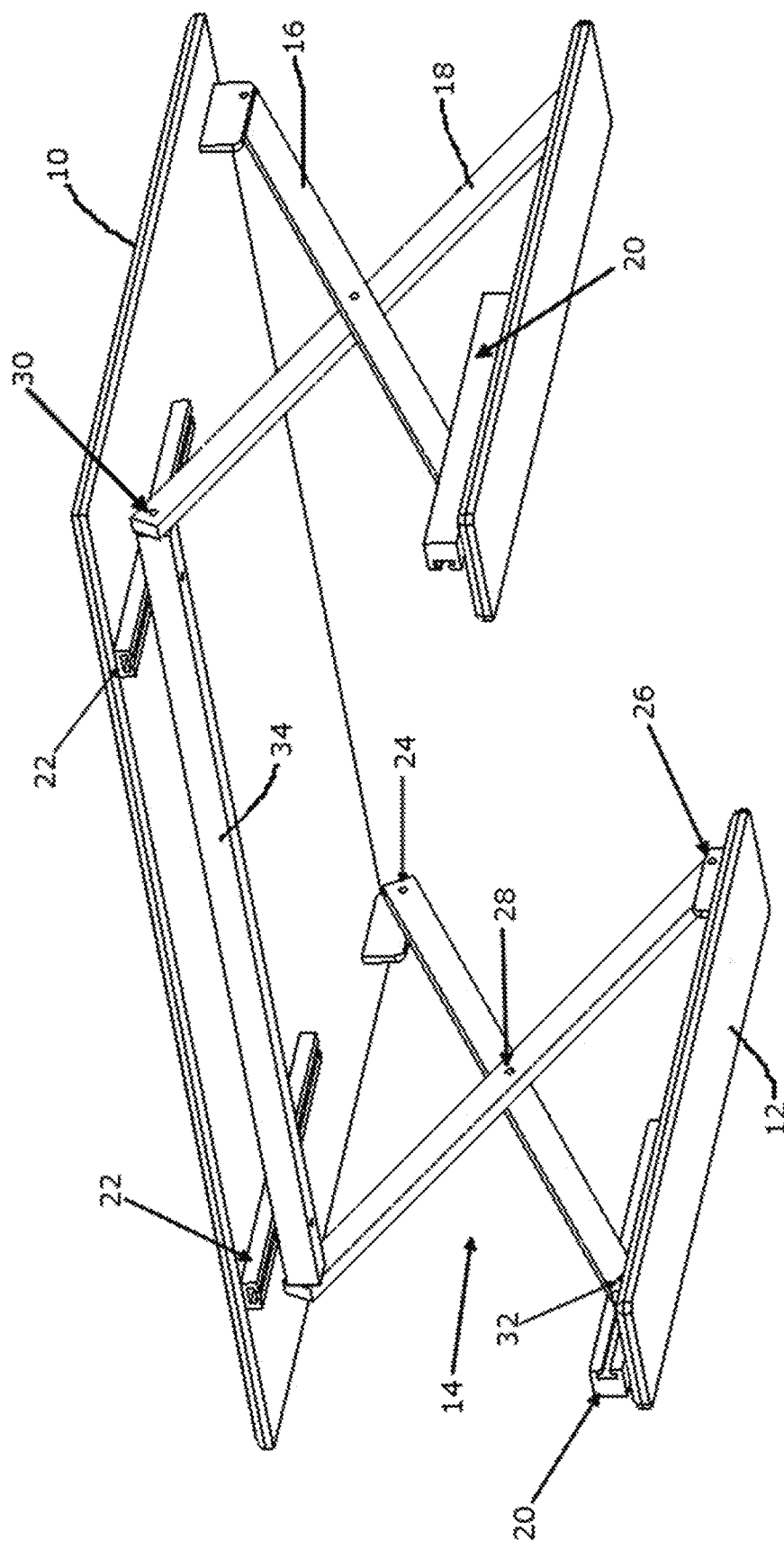


FIG. 2B

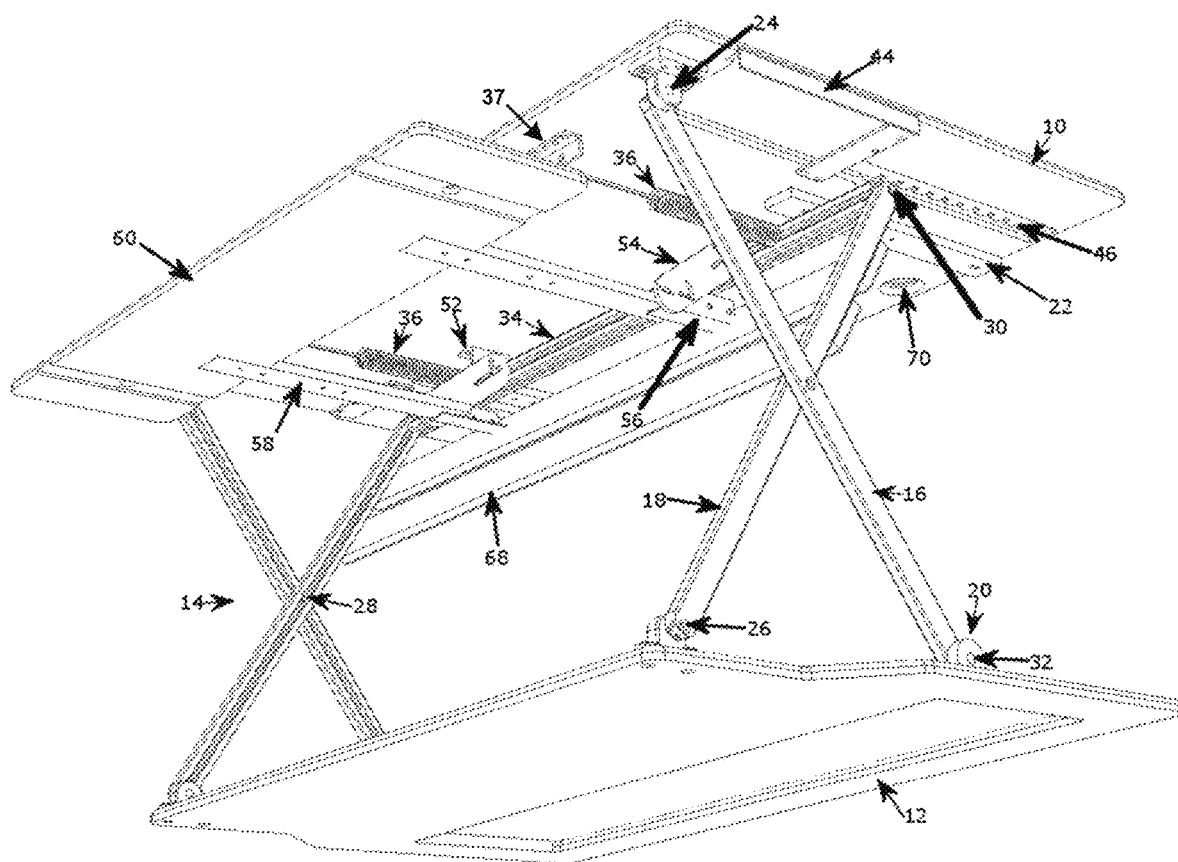


FIG. 2C

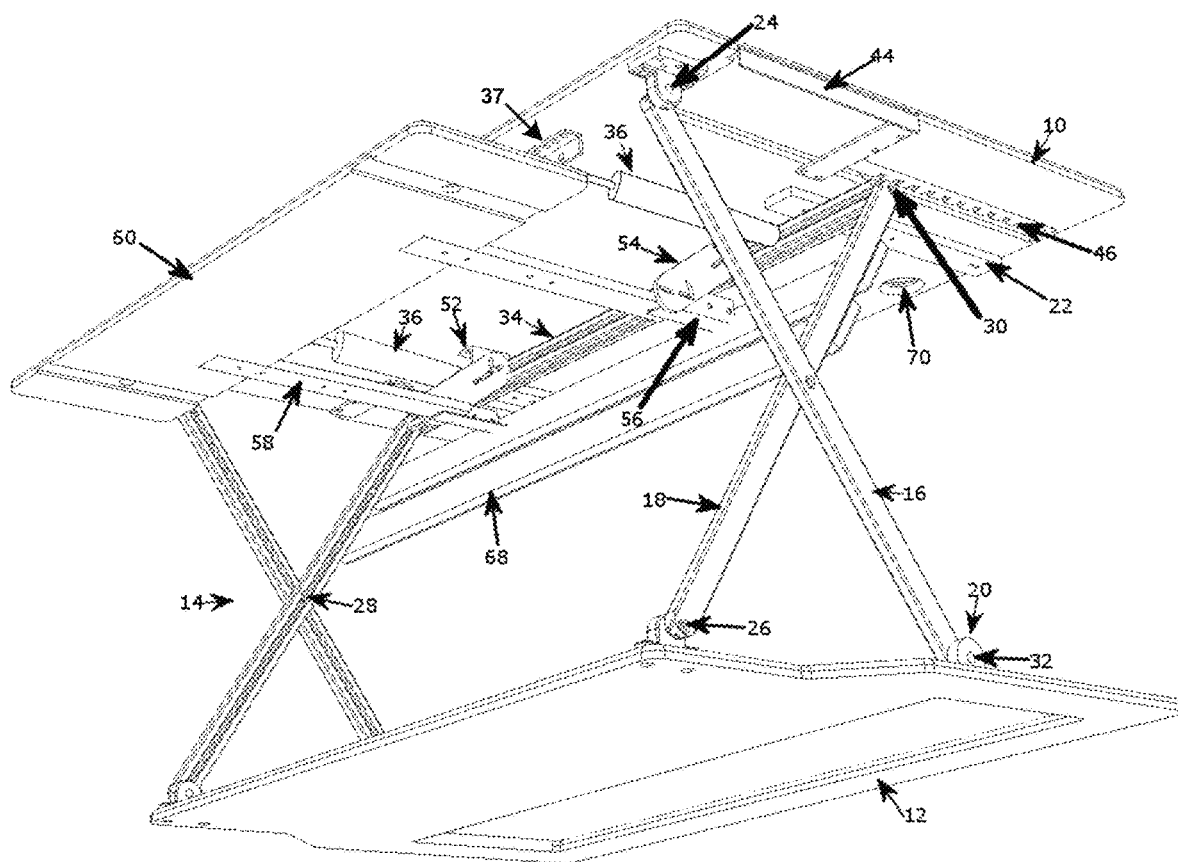


FIG. 2D

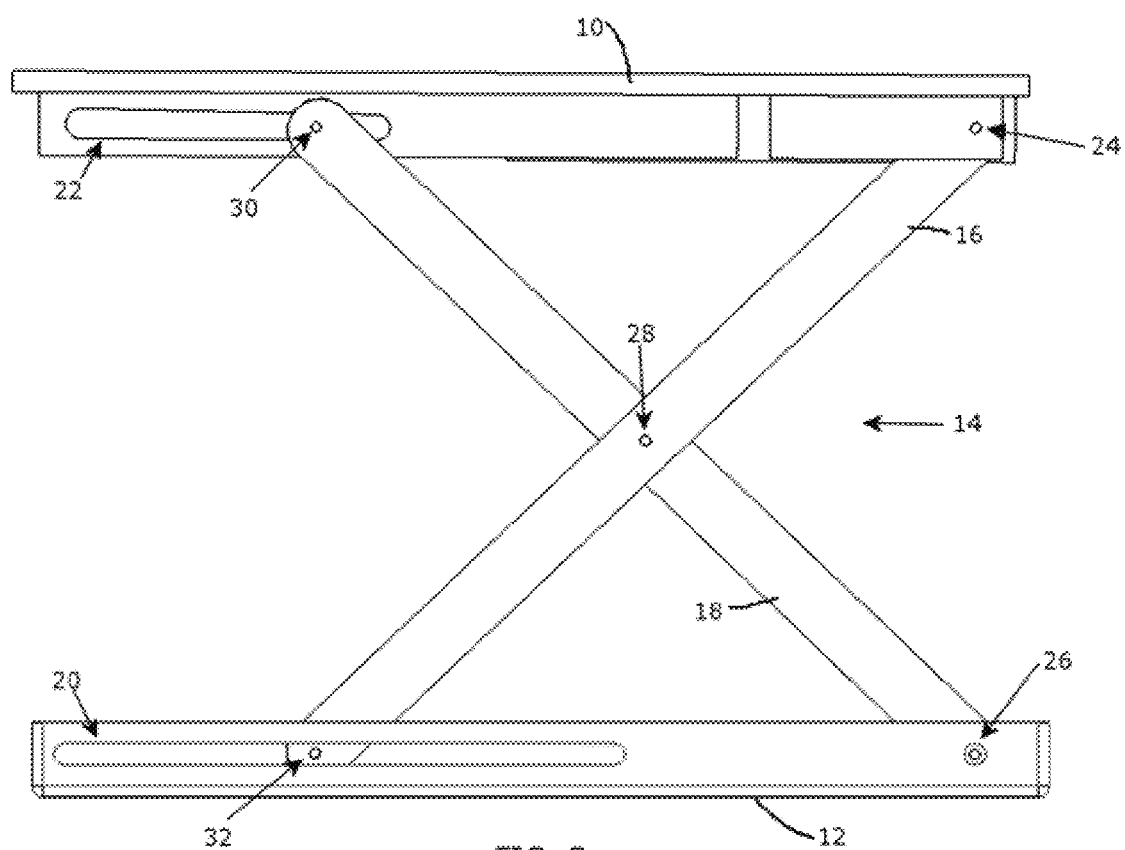
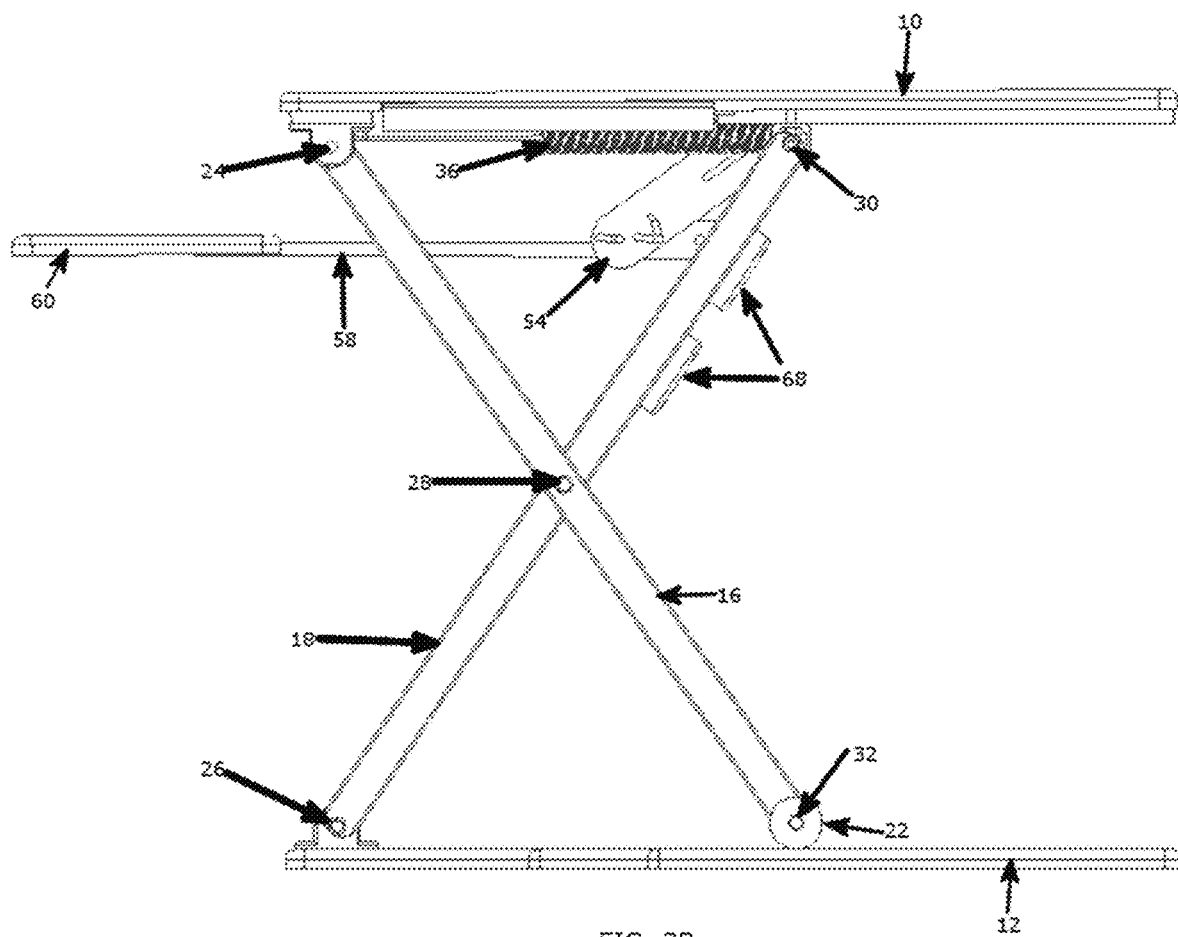


FIG. 3



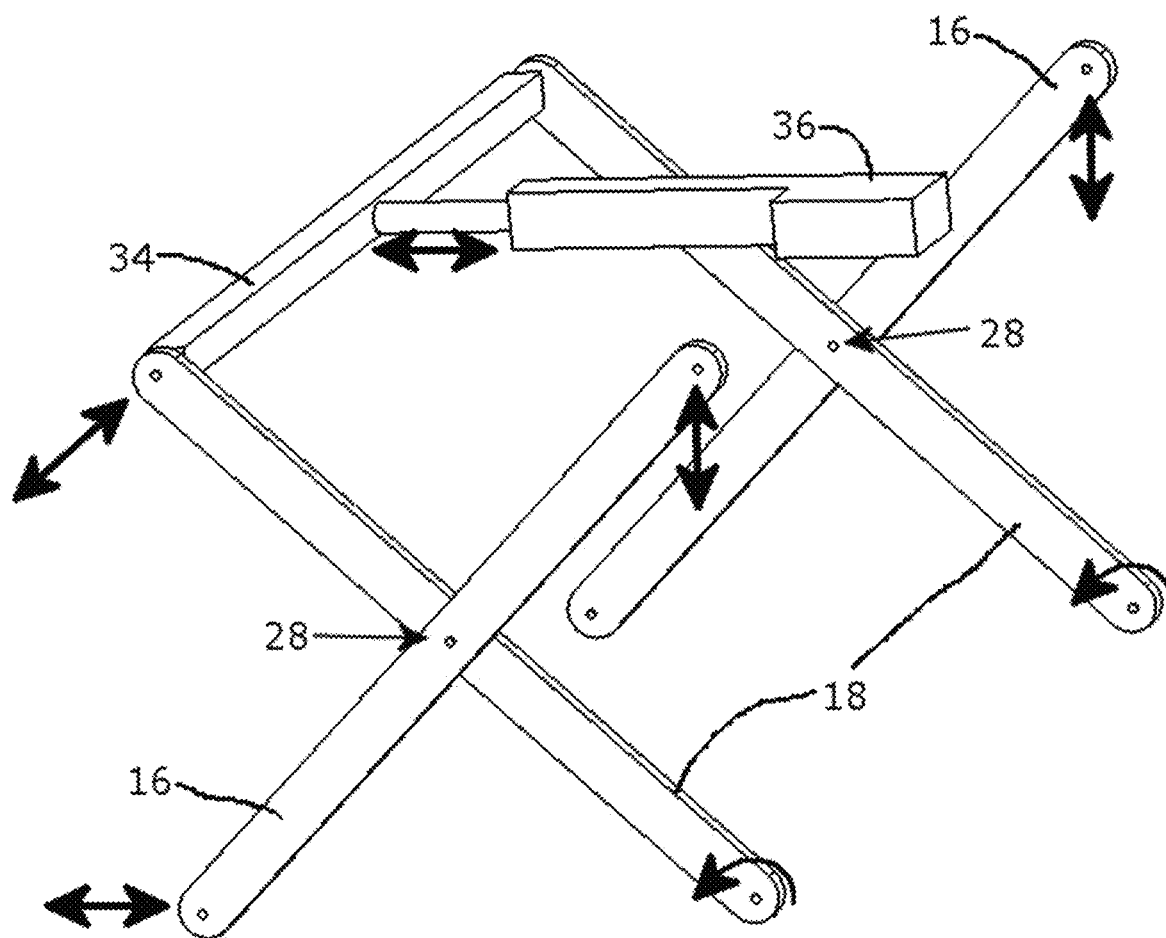


FIG. 4

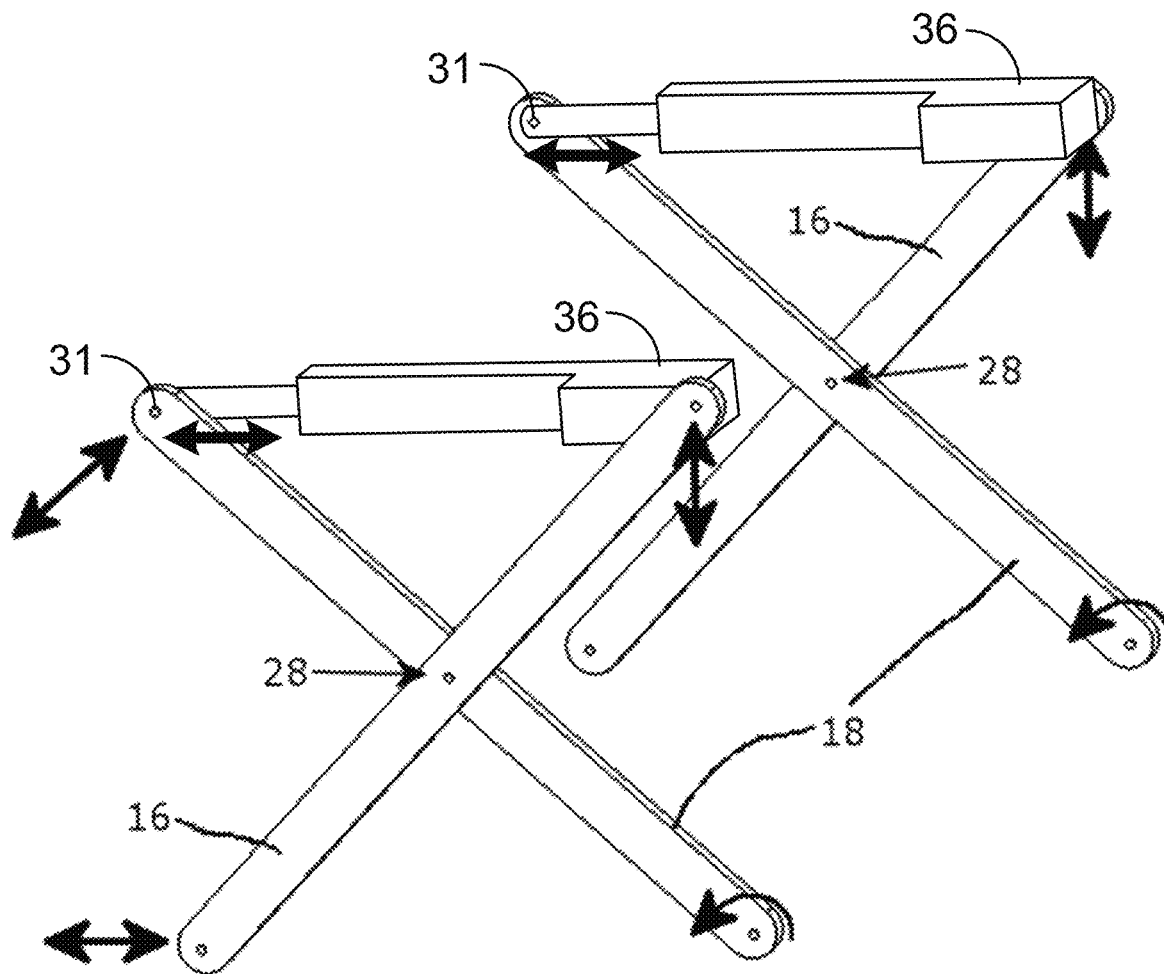


FIG. 4B

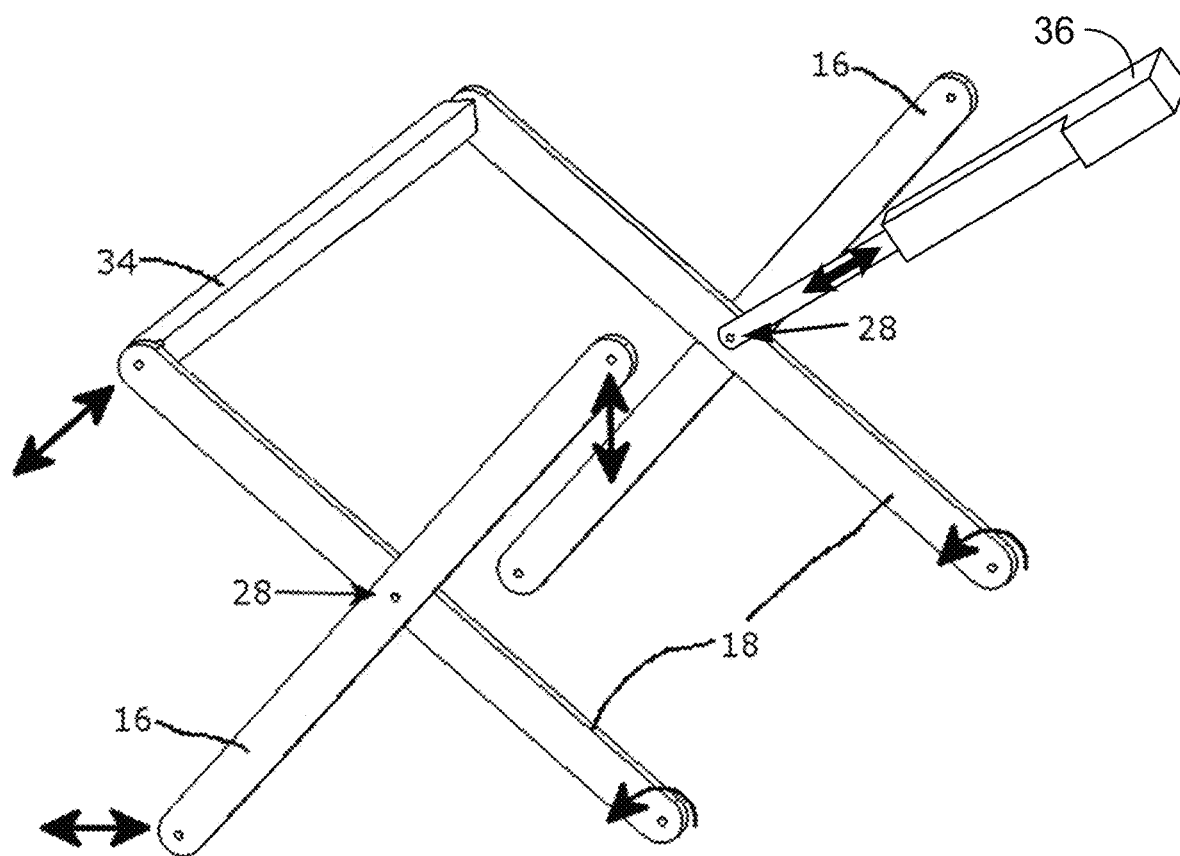


FIG. 4C

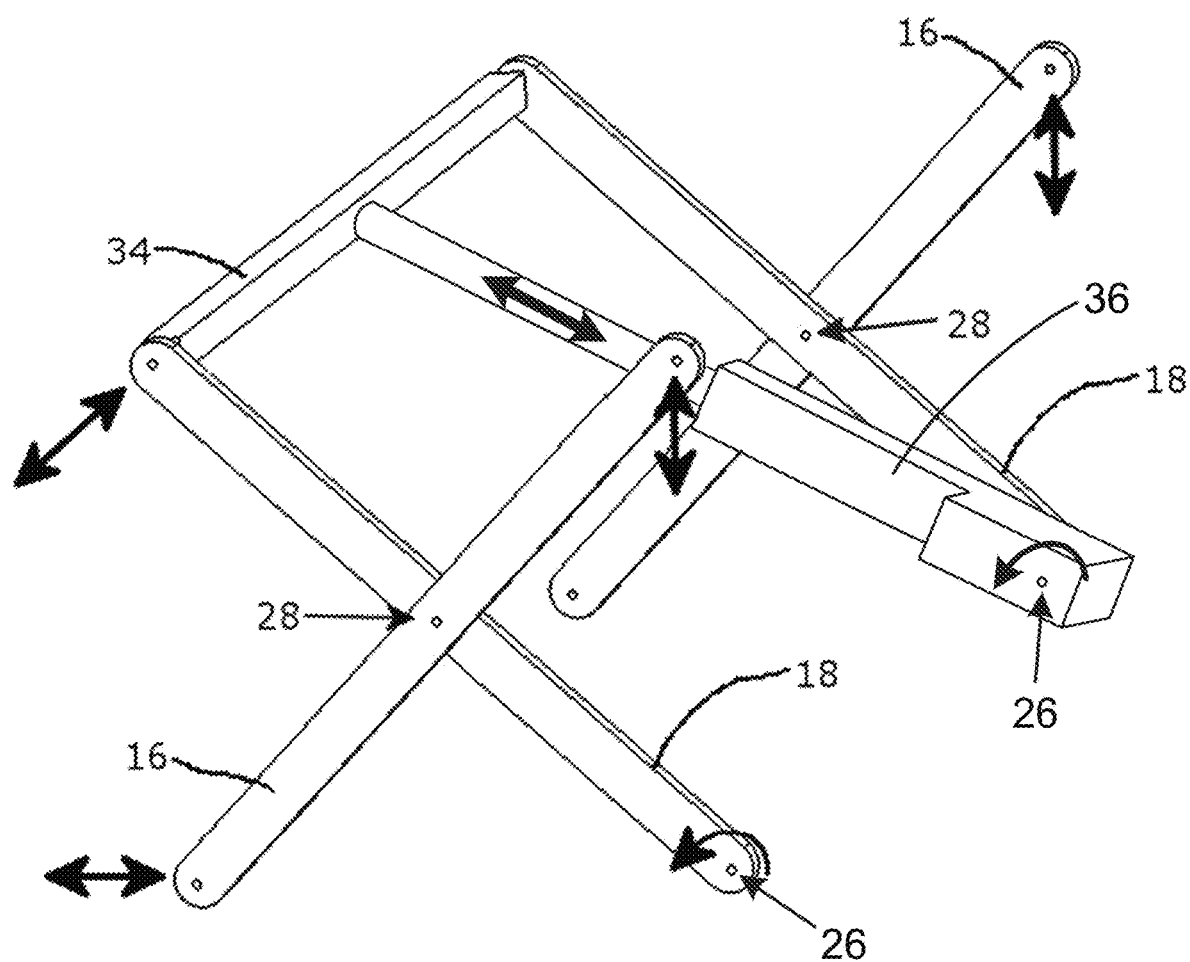


FIG. 4D

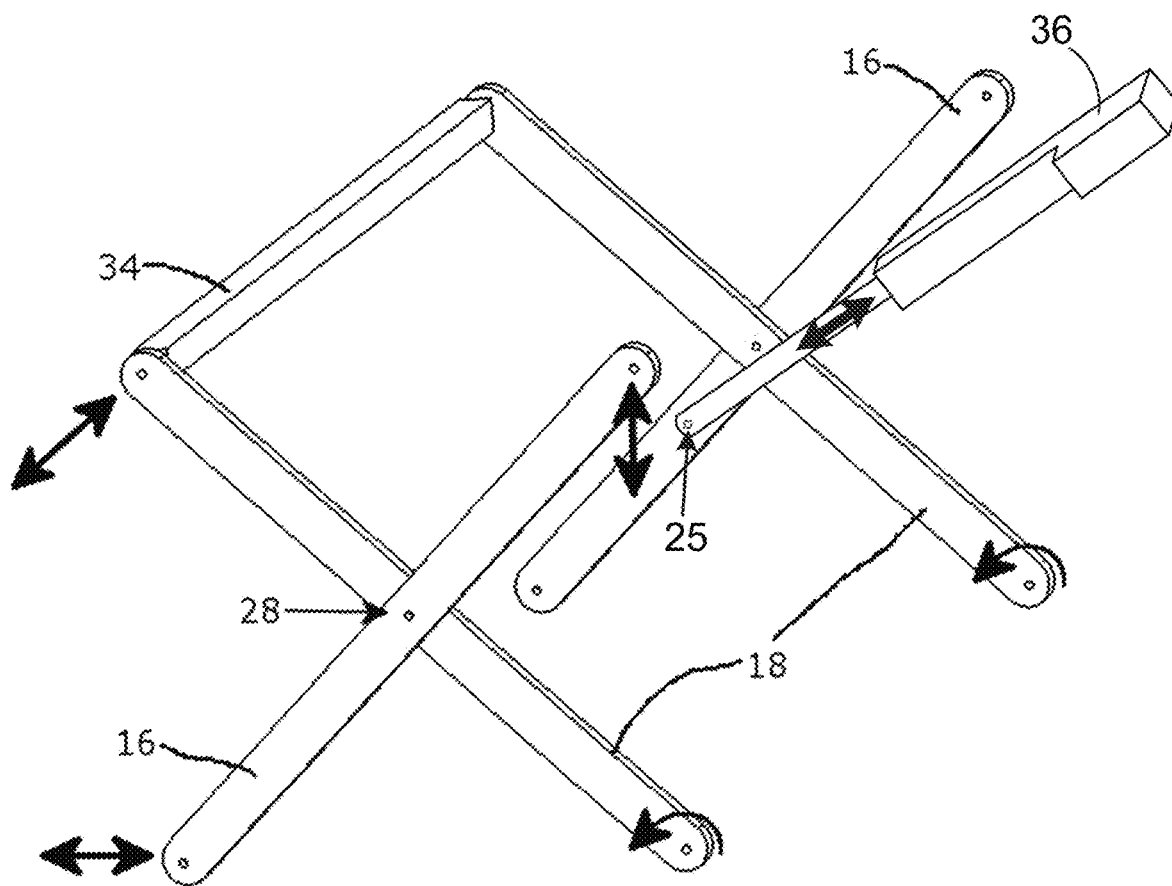
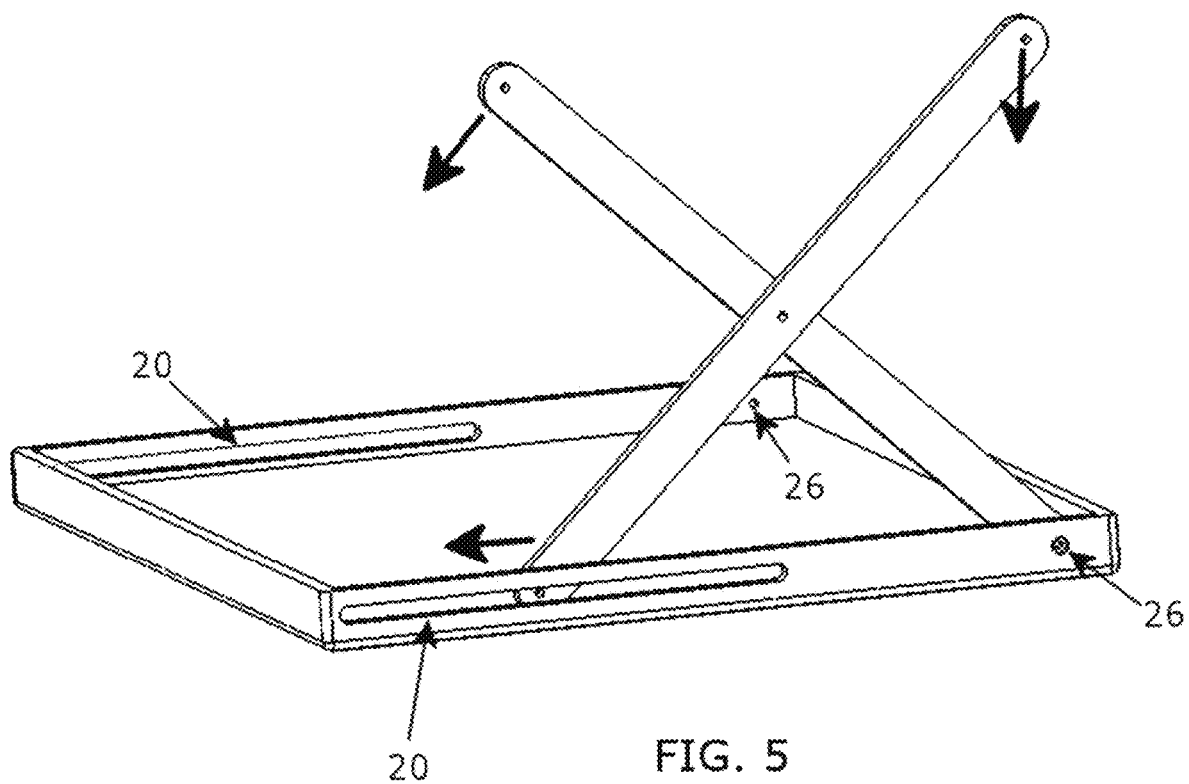


FIG. 4E



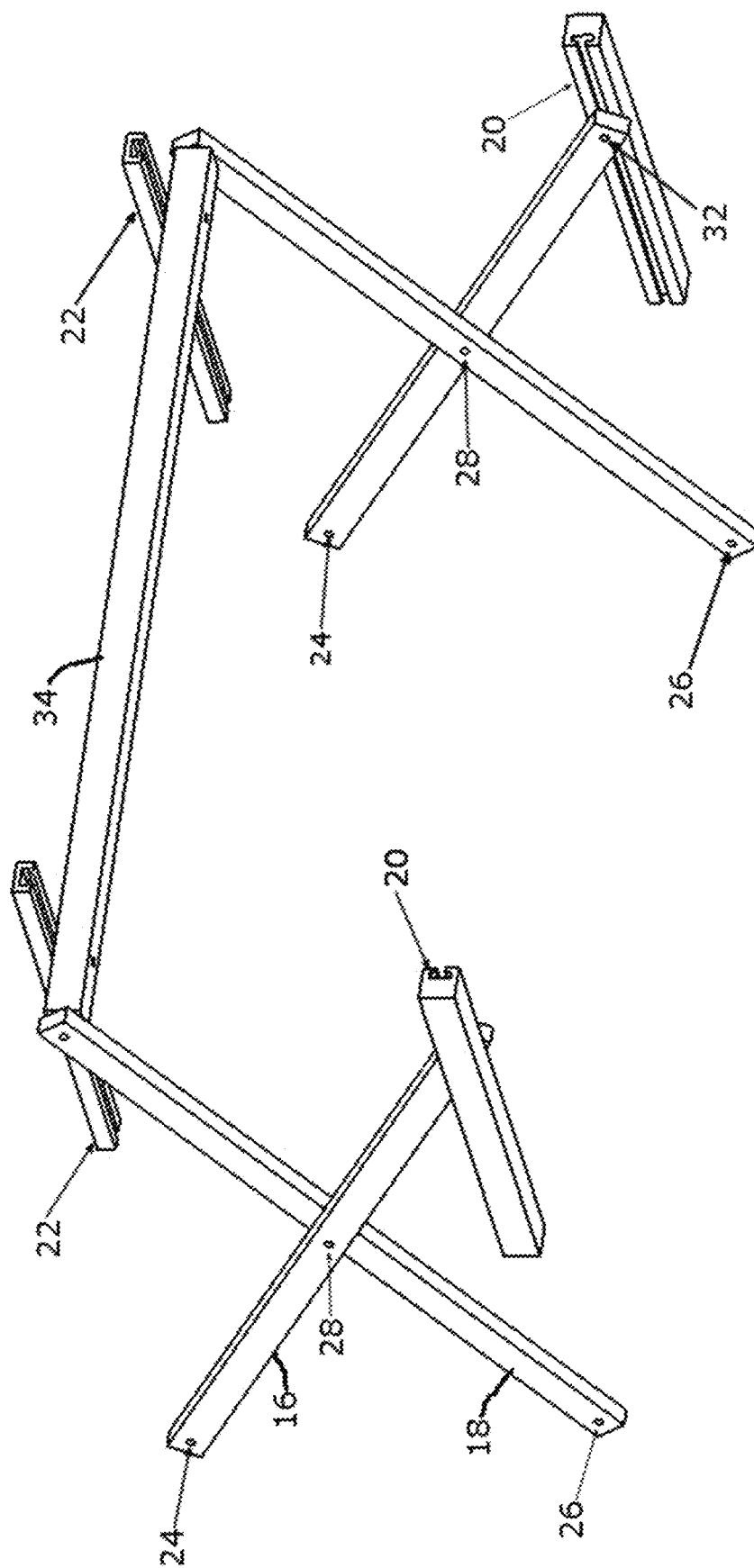


FIG. 5B

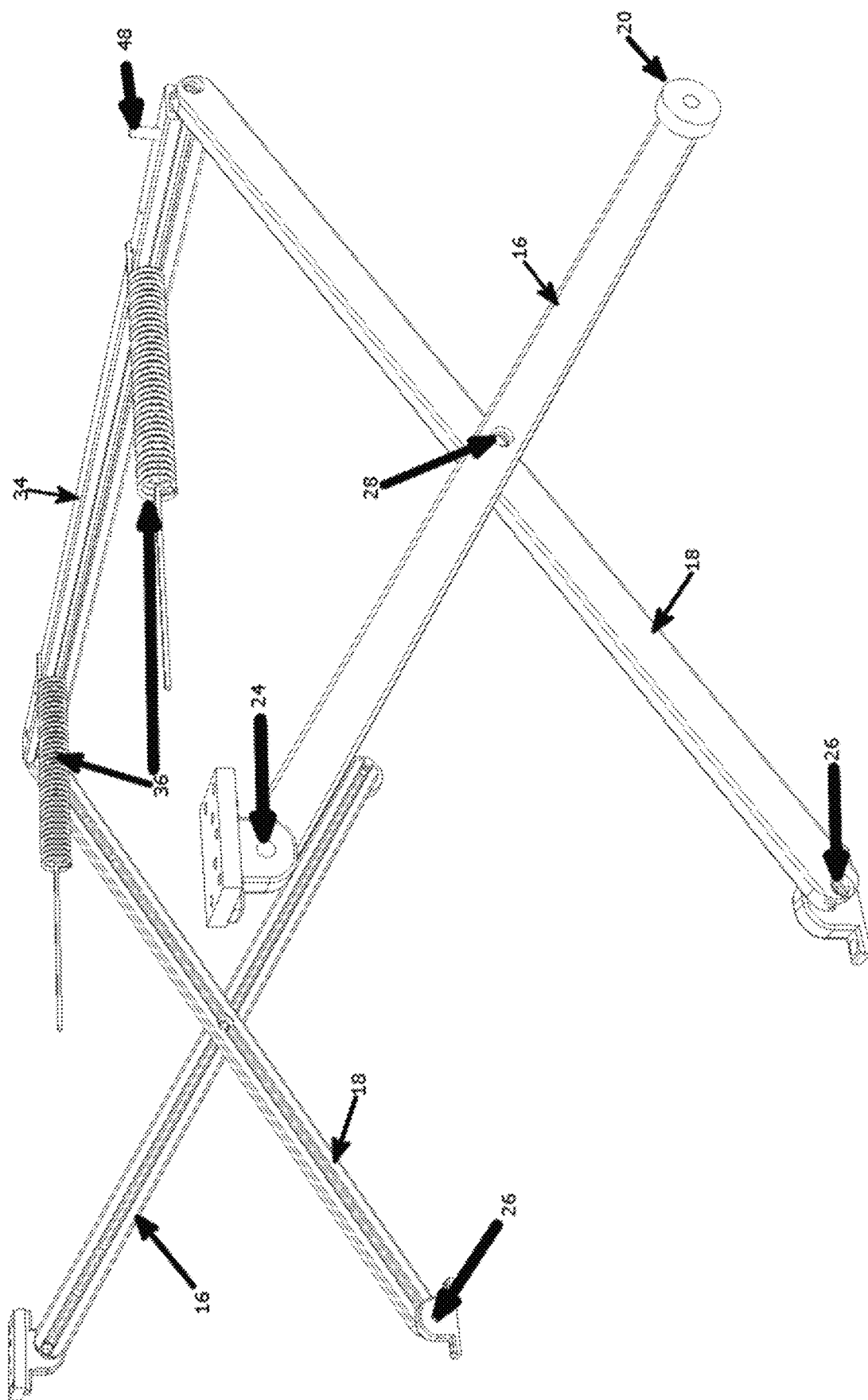


FIG. 5C

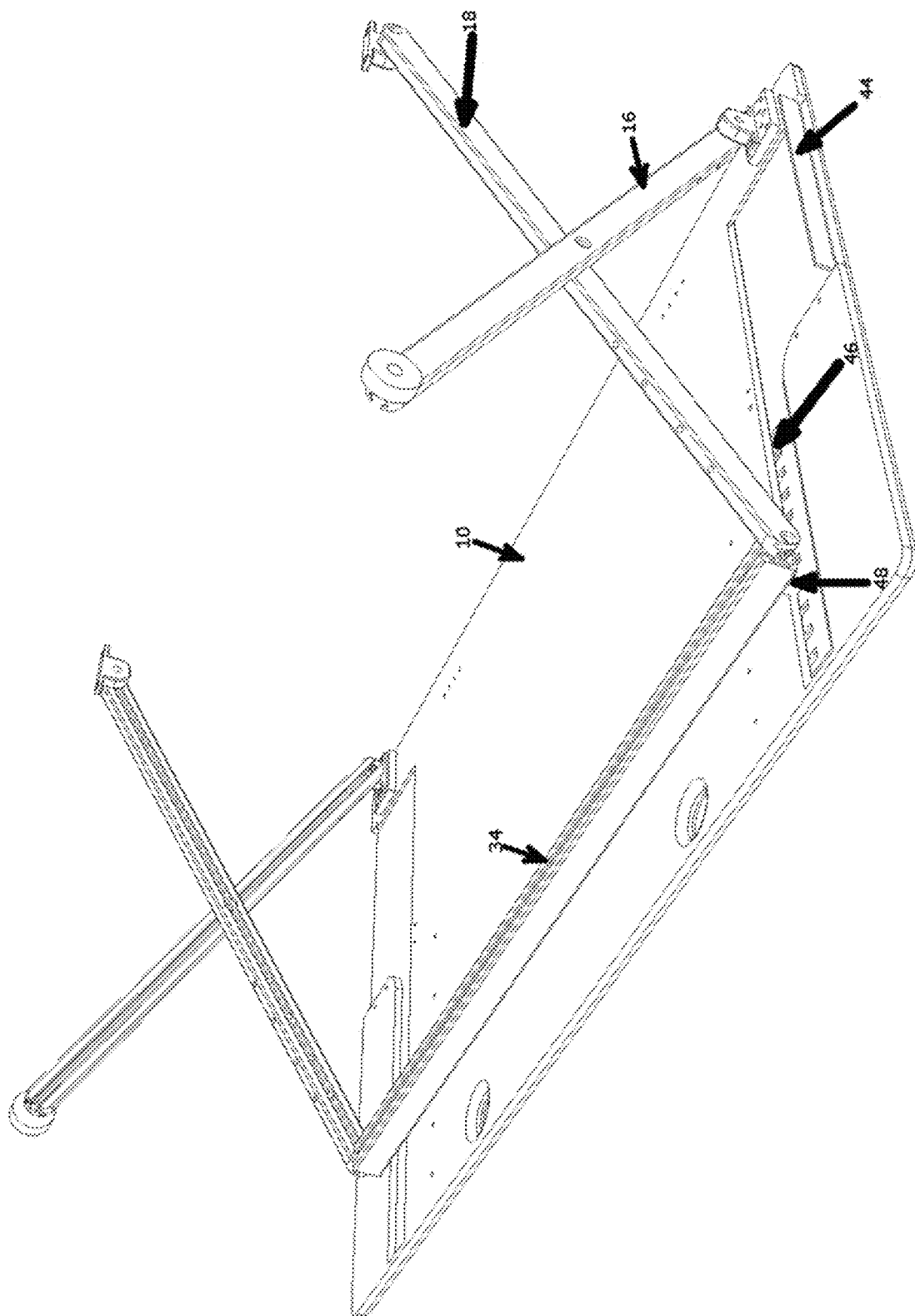


FIG. 5D

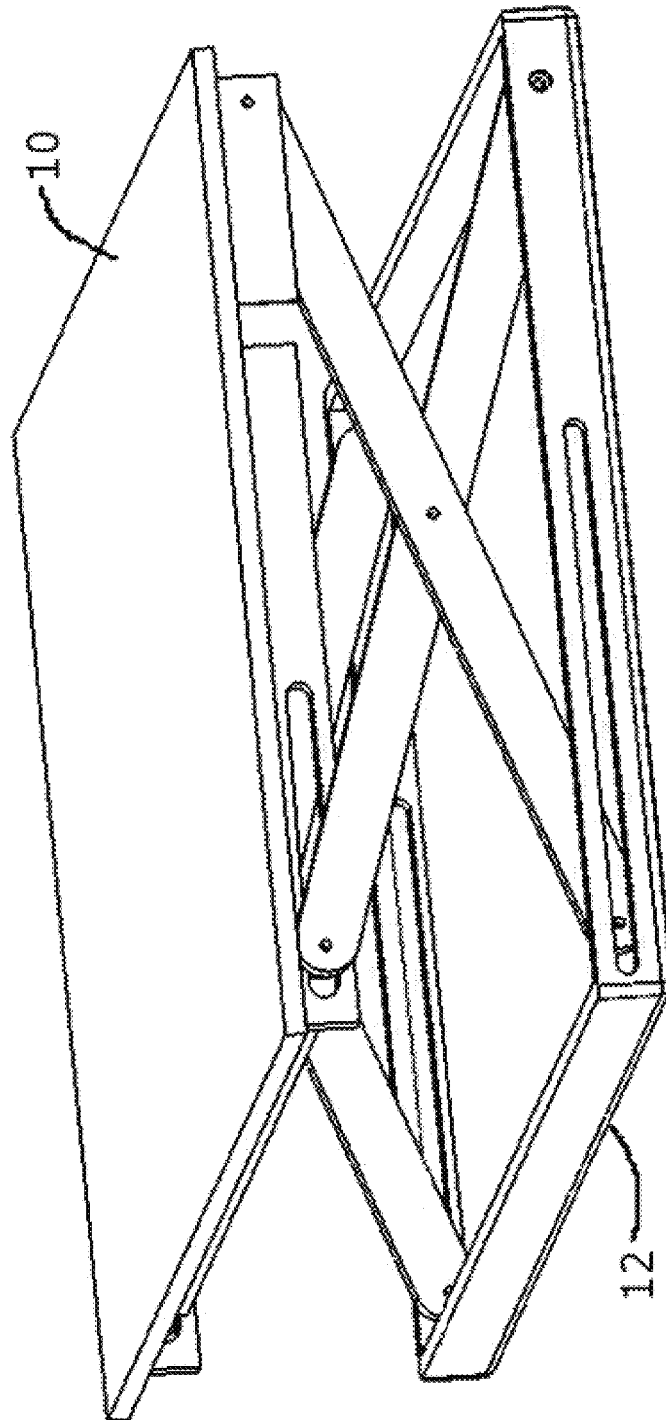


FIG. 6

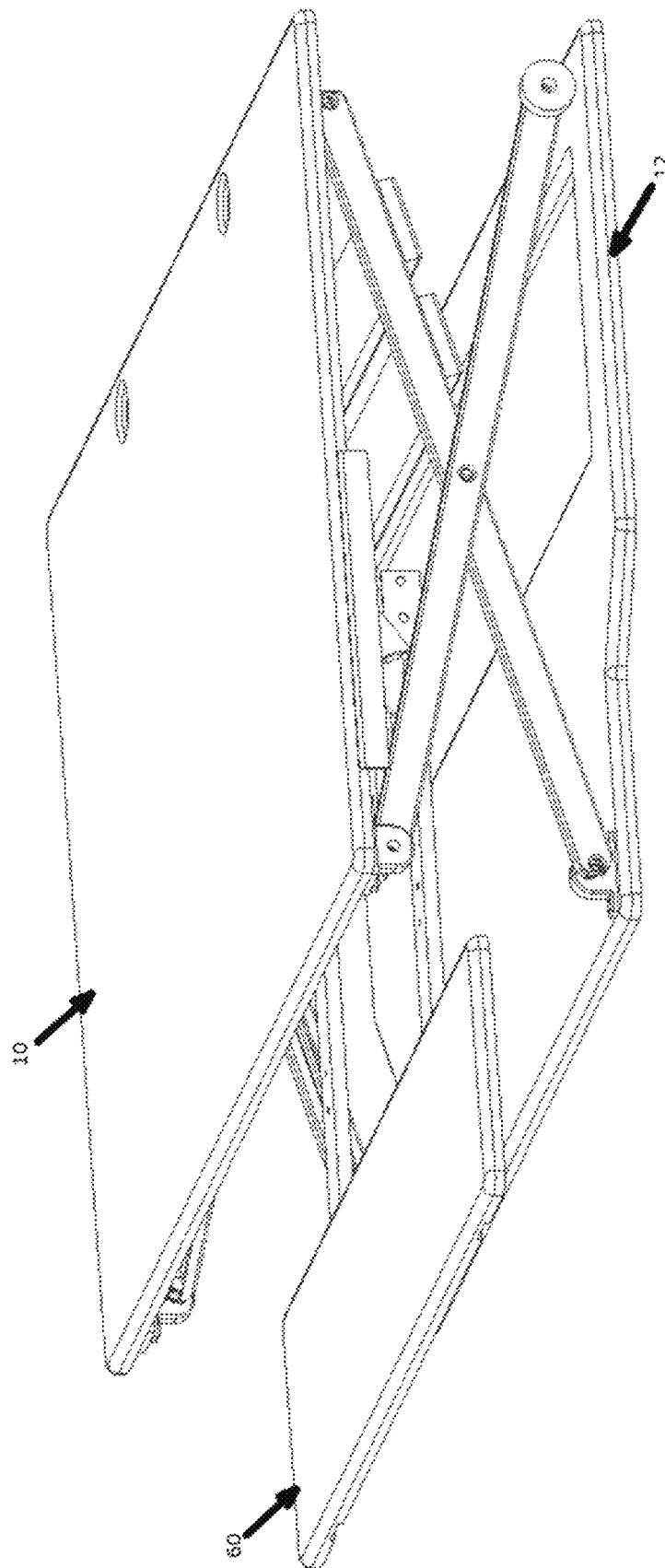


FIG. 68

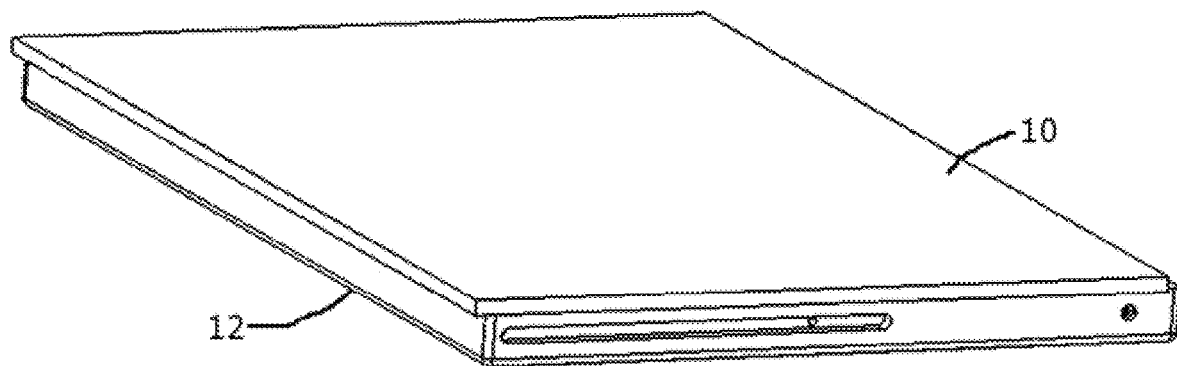


FIG. 7

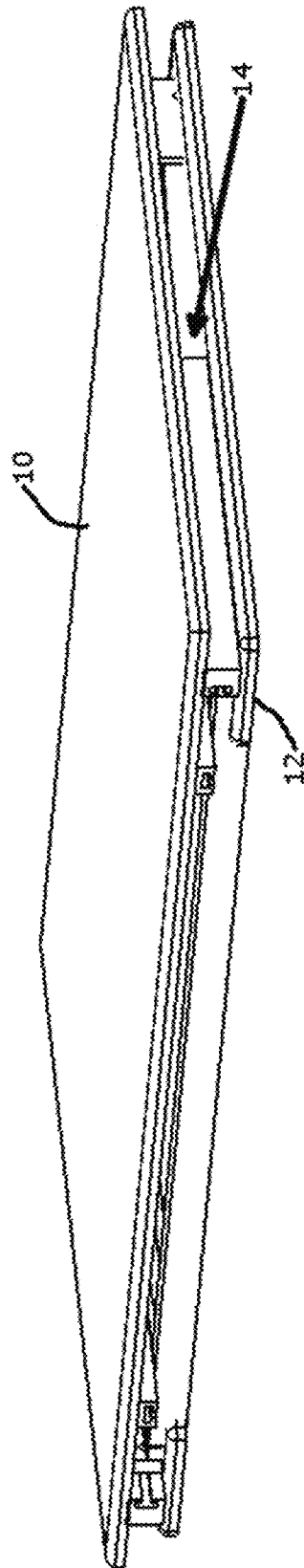


FIG. 7B

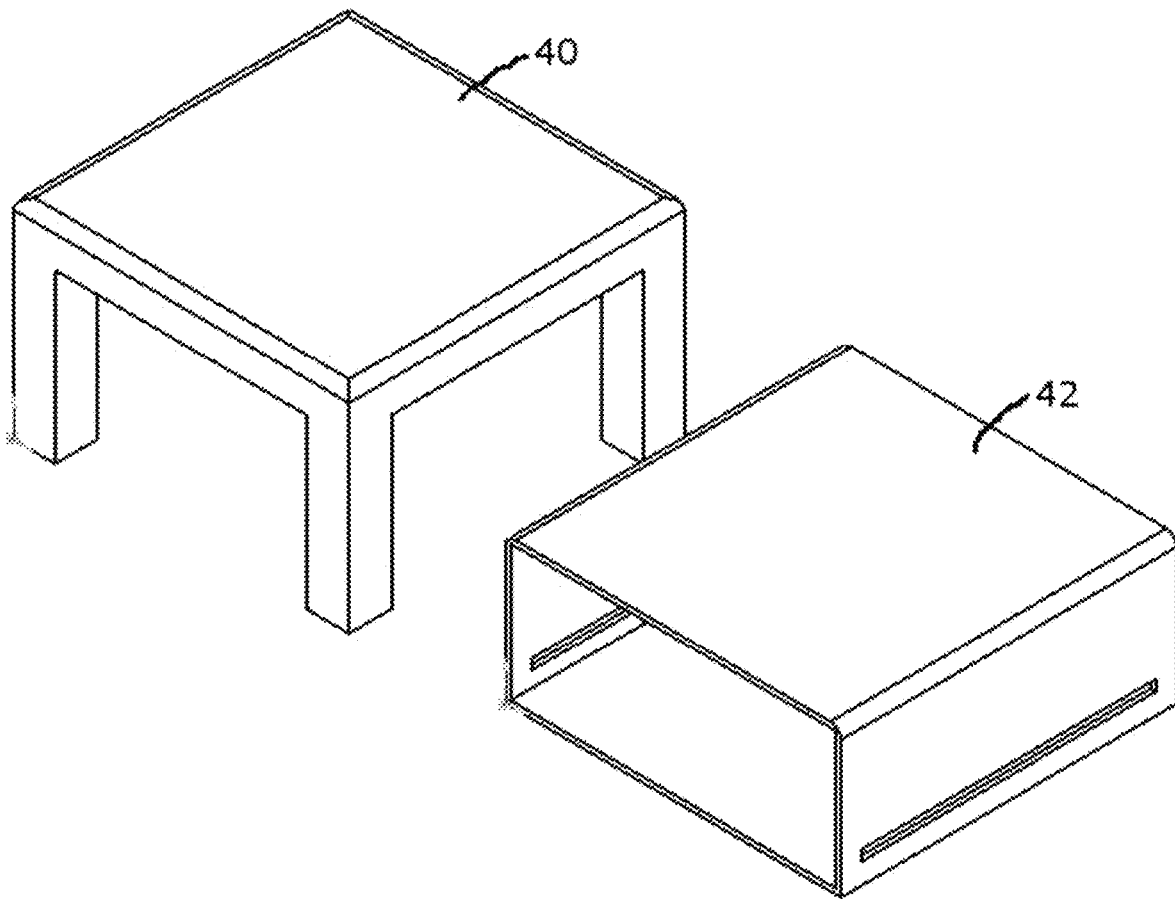


FIG. 8

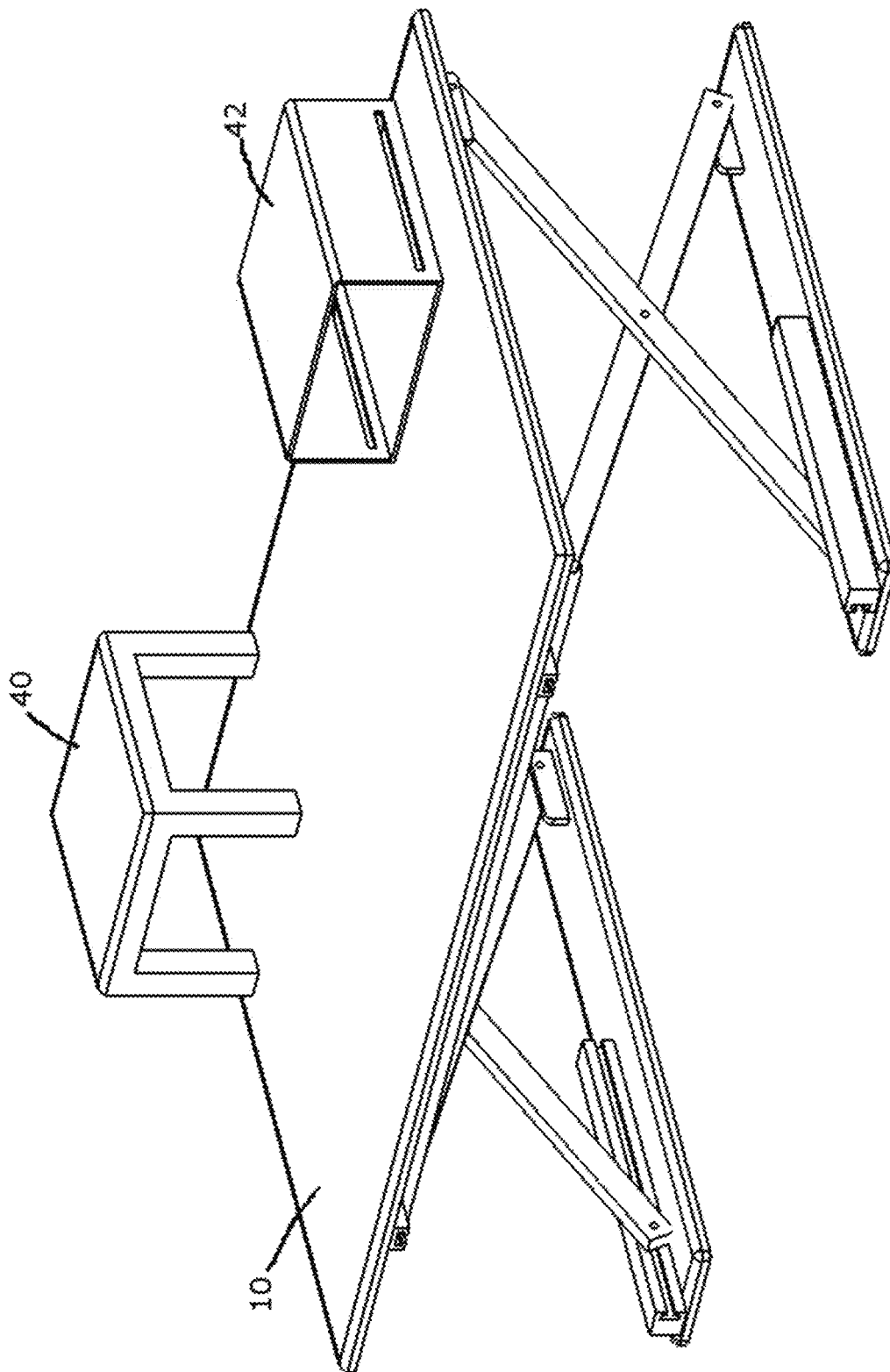


FIG. 9

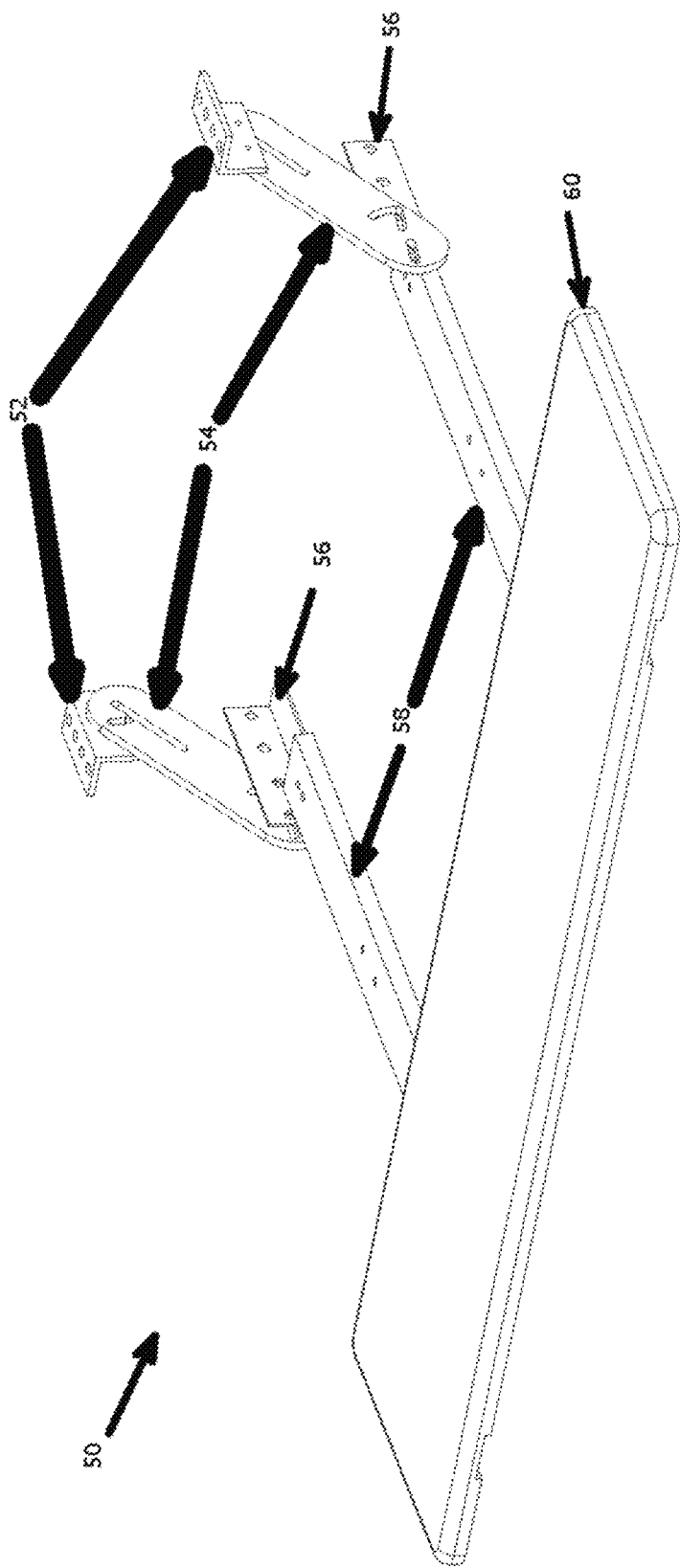


FIG. 10

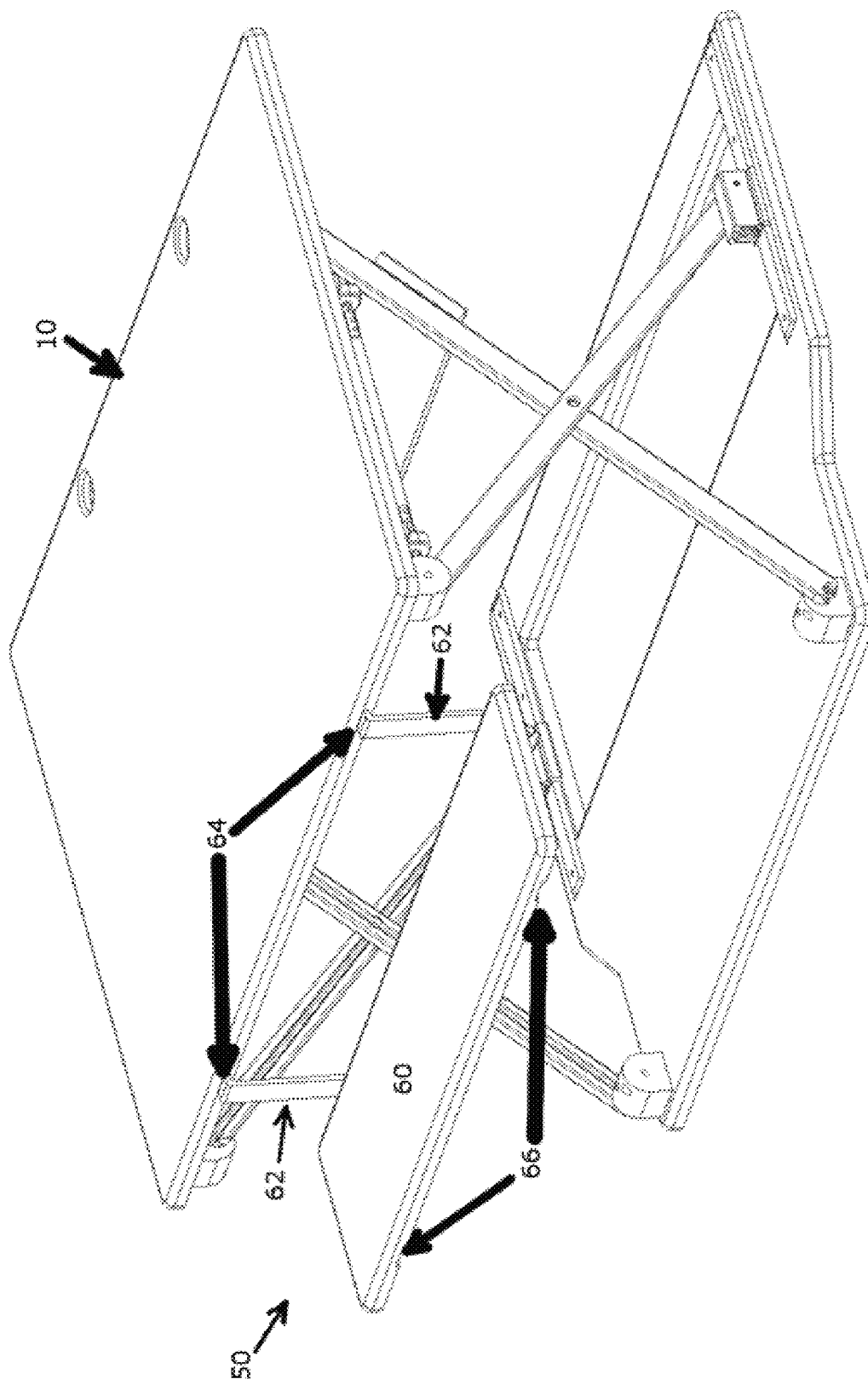
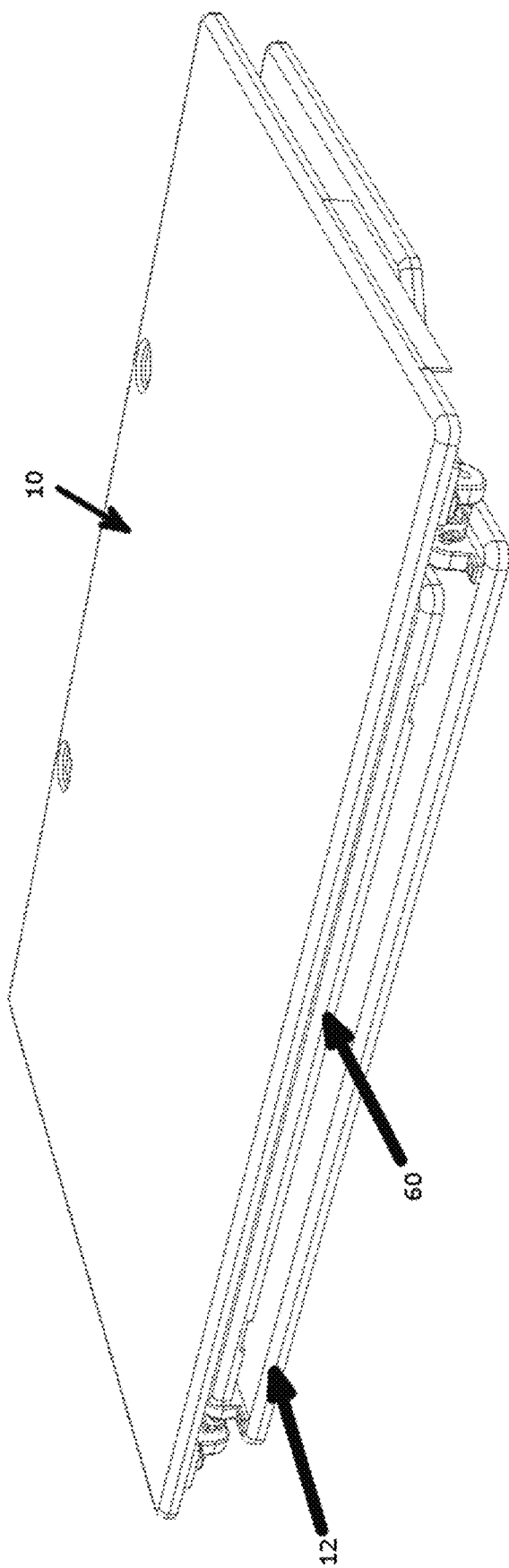


FIG. 10B



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**DESKTOP WORKSPACE THAT ADJUSTS VERTICALLY****CROSS REFERENCE TO RELATED APPLICATIONS**

This application is a continuation application of U.S. patent application Ser. No. 18/481,082, titled DESKTOP WORKSPACE THAT ADJUSTS VERTICALLY, filed Oct. 4, 2023, which is a continuation application of U.S. patent application Ser. No. 17/985,137, titled DESKTOP WORKSPACE THAT ADJUSTS VERTICALLY, issued as U.S. Pat. No. 11,910,926 on Feb. 27, 2024, which is a continuation application of U.S. patent application Ser. No. 17/493,812, titled DESKTOP WORKSPACE THAT ADJUSTS VERTICALLY, issued as U.S. Pat. No. 11,944,196 on Apr. 2, 2024, 2024, which is a continuation application of U.S. patent application Ser. No. 16/785,647, titled DESKTOP WORKSPACE THAT ADJUSTS VERTICALLY, issued as U.S. Pat. No. 11,134,773 on Oct. 5, 2021, which is a continuation application of U.S. patent application Ser. No. 16/372,334, titled DESKTOP WORKSPACE THAT ADJUSTS VERTICALLY, issued as U.S. Pat. No. 10,575,630 on Mar. 3, 2020, which is a divisional application of Ser. No. 15/628,558, titled DESKTOP WORKSPACE THAT ADJUSTS VERTICALLY, issued as U.S. Pat. No. 10,244,861 on Apr. 2, 2019, which is a divisional application of U.S. patent application Ser. No. 15/004,926, titled DESKTOP WORKSPACE THAT ADJUSTS VERTICALLY, filed Jan. 23, 2016, now abandoned, which claims the benefit of U.S. Provisional Patent Application No. 62/107,380, titled DESKTOP WORKSPACE THAT ADJUSTS VERTICALLY, filed Jan. 24, 2015. The entire contents of each of these related applications is incorporated by reference herein.

**TECHNICAL FIELD**

This disclosure relates to a desktop workspace platform that adjusts up and down vertically.

**BACKGROUND**

In recent years studies have been conducted to show the health benefits of not sitting or standing for prolonged periods of time. It has been shown that sitting for long periods of time, day after day, increases the rate of all-cause mortality. It has even been said that sitting is the new smoking. A healthier work environment could be achieved by standing a portion of your day that you typically spend sitting. A combination of standing and sitting can reduce your risk of obesity, diabetes, cardiovascular disease and cancer.

There are many different types of work surfaces today. Most of these are stationary, in that they do not adjust in height. In recent years, entire desks that adjust in height have become more common. Most people already have a stationary desk, so purchasing an entire new desk may be unreasonable for some.

**SUMMARY**

There are a few adjustable desk platforms that sit on an existing desk, however, designs of such products have left much room for improvement. Some notable areas for improvement include, but are not limited to; the need for straight vertical motion of the desktop platform where the

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work surface does not protrude out toward the operator when elevated, a motorized adjustable height mechanism or other motor assisted system, a holding or locking mechanism that does not limit the work surface to only preset heights, a higher maximum adjustable height to satisfy taller users, improved load distribution, improved design, improved appearance, increased load capacity, and a more compact design once in a lowered position.

A desktop workspace that adjusts vertically includes a work surface platform that acts as a work surface platform. A height adjustment mechanism allows the work surface platform to raise and lower to the desired height of the operator. This desktop workspace includes at least one set of arms as part of the height adjustment mechanism that utilizes a scissor motion to move the work surface platform up and down.

In one example, a desktop workspace that adjusts vertically is comprised of a work surface platform; a base configured to sit on an existing platform such as a desk; a height adjustable mechanism including at least one set of arms that connect at a pivot point creating a scissoring motion as part of the method to raise and lower the said work surface platform to various heights.

**BRIEF DESCRIPTION OF THE DRAWINGS**

FIG. 1 is a perspective view of an example adjustable desk including a work surface platform, base, and height adjustment mechanism.

FIG. 1B is a perspective view of an example adjustable desk including a work surface platform, base, and height adjustment mechanism, with alternative sliding mechanisms.

FIG. 1C is a perspective view of an example adjustable desk with alternative sliding mechanisms that incorporate rolling wheels, and a keyboard tray mechanism.

FIG. 1D is a perspective view of an example adjustable desk with alternative sliding mechanisms that incorporate rolling wheels, and a keyboard tray mechanism as shown in FIG. 1C, but without a base.

FIG. 2 is a perspective view from another angle of an example adjustable desk including a work surface platform, base, and height adjustment mechanism.

FIG. 2B is a perspective view from another angle of an example adjustable desk including a work surface platform, base, and height adjustment mechanism, with alternative sliding mechanisms.

FIG. 2C is a perspective view from another angle of an example adjustable desk with alternative sliding mechanisms that incorporate rolling wheels and a keyboard tray mechanism.

FIG. 2D is a perspective view an example adjustable desk with the alternative sliding mechanisms that incorporates rolling wheels and a keyboard tray mechanism as shown in FIG. 2C, but with gas springs rather than coil springs.

FIG. 3 is a side view of an example adjustable desk including a work surface platform, base, and height adjustment mechanism.

FIG. 3B is a side view of an example adjustable desk including a work surface platform, base, height adjustment mechanism, alternative sliding mechanisms, and a keyboard tray mechanism.

FIG. 4 is a perspective view of an example height adjustment mechanism from FIG. 1.

FIG. 4B is a perspective view of an example height adjustment mechanism as shown in FIG. 4, but without a cross beam.

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FIG. 4C is a perspective view of an alternative height adjustment mechanism to that shown in FIG. 4.

FIG. 4D is a perspective view of an alternative height adjustment mechanism to that shown in FIG. 4.

FIG. 4E is a perspective view of an alternative height adjustment mechanism to that shown in FIG. 4.

FIG. 5 is a perspective view of parts of an example adjustable desk including sliding mechanism locations and pivot points of this disclosure from FIG. 1.

FIG. 5B is a perspective view of parts of an example of a height adjustment mechanism of this disclosure from FIGS. 1 and 1B with alternative sliding mechanisms.

FIG. 5C is a perspective view of parts of an example of a height adjustment mechanism from FIGS. 1 and 1B with alternative sliding mechanisms.

FIG. 5D is a perspective view of parts of an example of a height adjustment mechanism and locking mechanism from FIG. 1C.

FIG. 6 is a perspective view of an example adjustable desk wherein the work surface platform is in a partially raised state.

FIG. 6B is a perspective view of an example adjustable desk where the work surface platform is in a partially raised state with an example keyboard tray mechanism.

FIG. 7 is a perspective view of an example adjustable desk in a very compact state, with the work surface platform in a completely lowered position.

FIG. 7B is a perspective view of an example adjustable desk in a very compact state, with the work surface platform in a completely lowered position, with alternative sliding mechanisms.

FIG. 8 is a perspective view of example elements intended to additionally raise the height of monitors or other items.

FIG. 9 is a perspective view of an example adjustable desk with monitor raising elements resting on top of the work surface platform.

FIG. 10 is a perspective view of parts of an example of a keyboard tray mechanism.

FIG. 10B is a perspective view of an example adjustable desk with an alternative keyboard tray mechanism attached.

FIG. 10C is a perspective view of an example adjustable desk with keyboard tray mechanism attached and in a closed position.

#### DETAILED DESCRIPTION

The Desktop Workspace That Adjusts Vertically, also referred to as the “desktop workspace” in this document, includes a device and a method to raise and lower a platform that is part of the device. An exemplary use of the device is a work surface such as a desk, which can be moved to a desired vertical position. For example, the platform could hold objects such as a laptop, monitor, tablet, keyboard, mouse, and other desk items such as a stapler. The Desktop Workspace That Adjusts Vertically may include ancillary devices such as a monitor raiser, an external keyboard holder, mouse holder, cable organizer, or other devices. The platform raises vertically without protruding out along the horizontal plane, keeping the individual using the device from having to step backward to use the work surface platform when it is in a raised position. This configuration allows the operator to utilize the work surface platform at various heights. The examples and description suggest the device is used for supporting typical desktop objects, but the scope of this disclosure is intended to support other objects and to be used in other applications.

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The Desktop Workspace That Adjusts Vertically can be placed on an existing surface to provide a variable height working area that is adjusted by the operator. The Desktop Workspace That Adjusts Vertically includes at least one set of two arms that connect along their lengths at a pivot point, allowing a scissoring motion, which is part of the method for raising and lowering the work surface platform. When raised, the work surface platform raises in a substantially straight motion so that it stays in-line with the base. An element or mechanism such as a spring or motor is configured to provide a force to assist in the elevation of the work surface platform. A locking mechanism is configured to secure the work surface platform at a given height.

The Desktop Workspace That Adjusts Vertically includes a height adjustment mechanism configured to assist in raising the work surface platform parallel to the surface it sits on, without moving back and forth or left to right; keeping the individual using the device from having to move backward to use the work surface platform when it is in a raised position. The height adjustment mechanism(s) may include items such as springs, gas springs, shock absorbers, an electric motor(s), or a linear actuator(s).

The Desktop Workspace That Adjusts Vertically is directed to help individuals from sitting or standing for prolonged periods of time while they work. Studies have shown that sitting or standing for long periods of time can be detrimental to one’s health.

The Desktop Workspace That Adjusts Vertically is designed to assist individuals to be more alert and productive as they work. Studies show that moving from a sitting to standing position and vice versa help the human body to be more awake and alert.

FIGS. 1, 1B, 1C, 2, 2B, 2C, 6, 7, 7B, 9, and 10C show examples of The Desktop Workspace That Adjusts Vertically in an assembled state. As shown, the desktop workspace includes a work surface platform 10, a base 12, and a height adjustment mechanism 14 residing between the work surface platform 10 and base 12. The examples show that platform 10 is a work surface platform that supports desk items; for example, monitors, tablets, Computers, notebooks, and other objects. The height adjustment example 14 includes at least one set of two arms 16 & 18. Arms 16 & 18 are connected at some point along their shafts at pivot point 28. These pivoting arms connect at pivot points 24 and 26 on one end and slide along a sliding mechanism 20 or 22 at pivot and sliding point 30 or 32. The arms pivot at 28, arm 16 slides along 20 and arm 18 slides along 22, creating a scissor motion to allow the work surface platform 10 to move up and down. This example with the pivoting arms moving in the scissor motion is the basis of the height adjustment mechanism 14. Base 12 is the base that the height adjustment mechanism 14 connects to. Base 12 consists of one piece of material or multiple pieces of material. FIG. 1 portrays base 12 as one piece, while FIG. 1B portrays base 12 as two pieces, and FIG. 1C portrays base 12 as one piece with portions removed.

Base 12 is connected to pivot point 26 and sliding mechanism 20. Sliding mechanisms 20 and 22 could also be directly connected to the arm(s) in the form of a slider or wheel, as portrayed in FIG. 1C. The example in FIGS. 1 and 2 shows the present sliding mechanisms 20 and 22 as a groove cut through the wall of the supporting material. FIGS. 1B and 2B show another design of the present sliding mechanisms 20 and 22 as channel or track. FIGS. 1C and 2C show yet another design of the present sliding mechanisms 20 and 22 as a rolling device such as a wheel or bearing. All three are methods to illustrate that there is more than one

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possible way to accomplish the intended sliding motion. Arm 16 attaches to the sliding mechanism 20 at point 32. Arm 16 moves back and forth along sliding mechanism 20 as part of the scissor motion used to obtain change in height of the work surface platform 10. The sliding action that sliding mechanisms 20 and 22 assist could be accomplished through means other than the illustrated examples, for example, a track system, roller wheel system, or some other means could be used to allow arm 16 and 18 to move in a back and forth motion. This disclosure is not intended to limit the means of the sliding motion, but to establish the fact that the sliding motion is part of the function of the adjustable height mechanism. The mentioned sliding motion is part of the overall scissor motion that is created by the design to vertically raise the work surface platform 10.

Pivot point 26 is the element that attaches the base 12 to arm 18. The examples in FIGS. 1 and 2 shows pivot 26 as being part of the wall of the base, and FIGS. 1B, 1C, 2B, and 2C shows pivot 26 as being a bracket or similar connected to base 12; pivot 26 could be located further in towards the center of base 12 and could be created as a stand-alone element such as a bracket or similar device. Pivot 26 is to be understood as a connection between base 12 and arm 18, and to be a pivot point that allows arm 18 to rotate as part of the scissor motion of height adjustment mechanism 14.

In some examples, the desktop workspace could exclude base 12, as shown in FIG. 1D. In such examples, height adjustment mechanism 14 connects directly to the desk or surface that the desktop workspace that adjusts vertically is sitting on. The lower portion of arm 18 connects directly to the surface with a pivot point similar to element 26. The lower portion of arm 16 connects to the surface and be guided to slide in a similar motion with an independent sliding mechanism such as, but not limited to, a track, channel, wheel, rail, or slot.

FIG. 4 shows an example of part of height adjustment mechanism 14, which assists in the vertical motion achieved to move the work surface platform 10 up and down in a smooth motion. Height adjustment 14 is designed so that it creates a vertical motion without any lateral or protruding motion side to side. Said another way, the scissor motion that height adjustment 14 creates allows work surface platform 10 to stay in alignment with base 12 as it raises or lowers. This alignment is intended, however some examples could include a method that does not align element 10 and 12 as raised and lowered.

Height adjustment mechanism 14 consists of one or more pairs of pivot arms 16 & 18, which have a pivoting point 28 at some point along their axis. Height adjustment mechanism 14 could also include a design where arms 16 & 18 do not actually connect at pivot point 28, but still provide a similar motion. Arm 16 connects at pivot element 24, and at point 32 which slide along sliding element 20. Similarly, arm 18 connects at pivot element 26 and at pivot point 30, which slides along sliding element 22. Height adjustment mechanism 14 also includes components that make the disclosure more rigid, such as cross beam supports labeled as element 68 in FIGS. 1C and 2C. Pivot arms, pivot points, and sliding elements are designed to fit compactly together when the desktop workspace is in a lowered position, as can be seen in FIGS. 7, 7B, and 10C. All elements align side-by-side in such a manner that when fully lowered the desktop workspace is very compact, looks sleek, and takes up minimal vertical space. The desktop workspace accomplishes such a compact state by having element 20 and 24

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ments' to not overlap when desktop workspace that adjusts vertically is in a fully lowered position providing a substantially compact state. The desktop workspace is not limited to specific elements or locations of elements to achieve the height adjustment motion that results in a compact design where elements do not overlap.

The illustrated examples of FIGS. 1 and 1B suggests that pivot points 26 and 24 are located in the back of desktop workspace, and that sliding mechanisms 20 and 22 are located in the front. The illustrated examples of FIG. 1C suggests that pivot points 26 and 24 are located in the front of the desktop workspace and that sliding mechanisms 20 and 22 are located in the back. Some examples include a design where the pivot points and sliding mechanisms are at opposite sides, or some combination of both.

As can be seen in FIGS. 2, 2B, 2C, 4, 5B, and 5C pivoting arms, are attached to a cross beam 34. Cross beam 34 assists in stabilizing the invention and assist all elements of the height adjustment mechanism to move in concert when a force is applied. The force can be applied from various methods and on various points of cross beam 34, pivot arms 16 & 18, pivot elements 26 & 24, or sliding mechanisms 20 or 22. FIG. 4D is a perspective view of an example height adjustment mechanism as shown in FIG. 4, but with element 36 connected on a point of cross beam 34 to one of pivot elements 26. FIG. 4E is a perspective view of an example height adjustment mechanism as shown in FIG. 4, but with element 36 connected to one of pivot arms 16 via an arm pivot 25. Some examples include a design where element 34 does not span across the mechanism connecting all or some of the arms.

FIG. 4 shows the force being applied by element 36 to cross beam 34. Element 36 can apply a pushing and pulling force to cross beam 36, which causes pivot arms 16 and 18 to move in a scissor motion. The example is intended to suggest that element 36, which applies force to height adjustment mechanism 14, can be a variety of different mechanisms, elements, or represent manual human force. For example, the force that element 36 provides could come from; a linear actuator, AC or DC motor, human force, gravity, springs, other objects with kinetic energy, or another source of force. For example, FIG. 4 illustrates element 36 as a linear actuator, while FIG. 5C illustrates element 36 as a pair of springs.

The combination of height adjustment mechanism 14 and a force represented by element 36, create the scissor motion that moves the work surface platform vertically up and down. Examples portrayed in FIGS. 4, and 5 show the scissor motion of height adjustment mechanism 14.

Examples can utilize element 36 or similar element in a different location; for example, the element could attach directly to arms 16 or 18, or to one of the pivot points, instead of to element 34. Some examples may not include element 34 or the like, where such a crossbeam or connection is not deemed necessary. FIG. 4B is a perspective view of an example height adjustment mechanism as shown in FIG. 4, but without a cross beam 34. In FIG. 4B, elements 36 attach directly to arms 18 through arm pivot points 31, instead of to element 34. FIG. 4C is a perspective view of an example height adjustment mechanism as shown in FIG. 4, but with element 36 connected to one of the scissoring pivot points 28 instead of to cross beam 34.

Examples in FIGS. 4, and 5 include arrows that show some of the possible motions of mechanism 14. Pivot arms are connected to one another at pivot point 28. As one end of arm 16 moves along sliding mechanism 20, the other end of the arm moves up or down vertically. When arm 18 pivots

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at point **26**, the other end of the arm slides along sliding mechanism **22**, which can be seen in FIGS. **2**, **2B**, and **2C** and moves up and down vertically.

The height adjustment mechanism moves vertically and is held or locked into position at various heights. Examples of the height adjustment mechanism use various methods to lock or hold in place. For example, element **36** acts as the locking device, or the locking device can be included in sliding mechanism(s) **20** & **22**, or the locking device can be included in pivot point(s) **26** and **24**, or the locking mechanism could entail another element not mentioned. FIG. **5D** portrays a locking device that could include element **34** or other element engaging with element **44**. Pins or other element, portrayed as element **48**, engage with teeth or other element, portrayed as element **46** to lock the height adjustment mechanism in a desired position. The locking element can include, but not limited to, a linear actuator, a motor, applied pressure, locking teeth, or some other method to prevent arms **16** and **18** from moving, so that work surface platform **10** does not change vertical height. Applications utilizing a linear actuator or similar can allow the operator to adjust the height without the limitations of preset heights that some locking mechanisms only provide. Instead of preset heights created by an element with features such as preset holes, the linear actuator or something similar would allow the operator to set the height limit by stopping the linear actuator or similar at any point the operator chooses. The desktop workspace includes a locking mechanism that maintains the vertical position of surface **10**; the examples are not limited to specific elements to achieve the height locking function.

Examples include a means to unlock the device so that the work surface platform **10** can change height. Examples can include, but not limited to, a button(s) to control a motor or the like, a handle that the user pulls on to unlock the device, or another device that unlocks the locking device. FIG. **5D** portrays an example of a locking mechanism where element **44** acts as a handle that once pressure is applied to can both lock and unlock the height adjustment mechanism by engaging or disengaging the teeth, element **46** or similar to pin, element **48** or similar. Unlocking elements are suggested, however, examples are not limited to specific elements to achieve the unlocking function.

The example shows sliding element(s) **22** and pivot element(s) **24** connect the height adjustment mechanism **14** to the work surface platform **10**. The example allows for the work surface platform to be raised and lowered, as well as locked into the desired position of the individual using the desktop workspace. This allows the user to utilize the desktop workspace that adjusts vertically while in a seated position or a standing position.

FIG. **8** portrays the current design of elements **40** and **42**, which could be used to elevate a monitor, laptop, or other items to a level higher than that of work surface platform **10**. Additionally raising a monitor can create a more comfortable and healthier work space for the operator by bringing their screen(s) to a position closer to eye level. FIG. **9** shows elements **40** and **42** sitting on work surface platform **10**. Elements **40** and **42** are presently designed to be able to sit anywhere on surface **10**. Examples are not intended to limit the design of elements **40** and **42**. Elements **40** and **42** are intended to represent a method in which a monitor(s) can be elevated to height higher than if it were sitting on work surface platform **10**. It is to be understood that element **40** or **42** could be designed differently and still accomplish its function to raise the height of a monitor(s) or other items.

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FIGS. **10**, and **10B** show an example of part of keyboard tray mechanism **50**, which provides a platform for the user to place items such as a keyboard, mouse, or other items on. Keyboard mechanism **50** is configured move to a position that is in an outward and lowered position with respect to surface **10**. Such a position can provide a more ergonomic location of the keyboard and mouse for the user. Some examples include a design where the keyboard tray can be removed, adjusted, or designed so that it extends out when in use and is compactly stored under surface **10** when not in use.

FIGS. **10** and **10C** show an example of Keyboard tray **50** where it is configured to move underneath and flush with surface **10** to allow this disclosure to maintain its compact state once in a closed position. Bracket **52** connects to channel plate component **54**, which connects to bracket **56**, which connect to slider **58**, which connect to keyboard platform **60**. When the user applies an inward and upward force to platform **60**, channeled plate component **54** and slider **58** allow the keyboard tray mechanism to move to a position that is compactly positioned underneath platform **10** as portrayed in FIG. **10C**. Conversely, when an outward and downward force is applied to platform **10**, elements **52**, **54**, **56**, and **58** allow mechanism **50** to be in an out and down position as portrayed in FIGS. **1C** and **2C**. Said more specifically, plate **54** contains channels or grooves that guide brackets **52** and **54** connect to with pins, screws, or similar. When the user pulls or pushes up, down, in, or out on the platform **60**, the channels or grooves in plate **54** along with the sliding motion of slider **58** guide the platform to either rest in an outward state for typing or tucked away under the work surface platform **10**.

FIG. **10B** shows an example of keyboard tray mechanism **50** that attach to platform **10**. Bracket **62** attaches to platform **10** at element **64** and keyboard platform **60** at element **66**. Element **64** and **66** consists of a channel, bracket, or other means to attach bracket **62** to both platform **10** and platform **60**.

Elements for keyboard tray mechanism **50** are suggested, however, examples are not limited to specific elements to achieve the function of the keyboard tray mechanism.

The intention of the different examples discussed is not intended to limit the scope of this disclosure. The description and terminology is not intended to limit the scope and applicability of this disclosure. It should be understood that other terminology, parts, components, and layouts could be used that would still embody the intentions of this disclosure. Individuals skilled in the art will recognize that examples described have suitable alternatives. It is also noted that the examples are not limited to specific construction materials, and that various suitable materials exist for the elements of this disclosure.

What is claimed is:

1. A desktop workspace that adjusts vertically, comprising:
  - a work surface platform;
  - a base configured to sit on an existing platform;
  - a height adjustment mechanism connecting the work surface platform and the base, the height adjustment mechanism including:
    - a set of pivot arms including a base pivot arm pivotably connected to the base and a platform pivot arm pivotably connected to the work surface platform, the base pivot arm pivotably connected to the platform pivot arm to provide a scissoring motion when raising and lowering the work surface platform to various heights;

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- a first sliding mechanism on an end of the platform pivot arm between the end of the platform pivot arm and the base; and
- a second sliding mechanism on an end of the base pivot arm between the end of the base pivot arm and the work surface platform; and
- a force applying mechanism attached to the height adjustment mechanism to provide a force to assist in elevation of the work surface platform,
- wherein the force applying mechanism is a spring that acts as a locking device that holds the work surface platform at various heights above the base,
- wherein the force applying mechanism is adjacent an underside of the work surface platform and extends between an underside of the work surface platform and the height adjustment mechanism along a direction generally parallel to a work surface of the work surface platform.
2. The desktop workspace of claim 1, wherein the base pivot arm is a first base pivot arm, the height adjustment mechanism further comprising:
- a second base pivot arm; and
- an element that connects the first base pivot arm to the second base pivot arm,
- wherein the force applying mechanism is attached to the element.
3. The desktop workspace of claim 2, wherein the element is attached on the same side of the base pivot arm as the second sliding mechanism relative to the pivot connection between the base pivot arm and the platform pivot arm.
4. The desktop workspace of claim 2, wherein the element includes a cross beam.
5. The desktop workspace of claim 1, wherein the platform pivot arm is a first platform pivot arm, the height adjustment mechanism further comprising a second platform pivot arm.
6. The desktop workspace of claim 1, wherein the scissoring motion when raising and lowering the work surface platform to various heights of the height adjustment mechanism moves the work surface platform parallel to the existing platform.
7. The desktop workspace of claim 6, wherein the scissoring motion when raising and lowering the work surface platform to various heights of the height adjustment mechanism moves the work surface platform without moving back and forth or left to right.
8. The desktop workspace of claim 1, further comprising a keyboard platform that protrudes out, down, and parallel to the work surface platform.
9. The desktop workspace of claim 8, further comprising a keyboard tray mechanism configured to hold the keyboard platform in the position that protrudes out, down, and parallel to the work surface platform and to allow the keyboard platform to be stored under the work surface platform.
10. The desktop workspace of claim 1, wherein the locking device includes a user-operated handle for controlling the locking device.
11. The desktop workspace of claim 1, further comprising a keyboard holder.
12. The desktop workspace of claim 1, wherein the force applying mechanism is configured to apply pushing and pulling forces to move the set of pivot arms in the scissoring motion.

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13. The desktop workspace of claim 1, wherein the force to assist in elevation of the work surface platform extends along the direction generally parallel to the work surface of the work surface platform.
14. The desktop workspace of claim 1, wherein the force applying mechanism acts as a locking device that holds the work surface platform at any various height above the base chosen by a user.
15. A desktop workspace that adjusts vertically, comprising:
- a work surface platform;
- a base configured to sit on an existing platform;
- a height adjustment mechanism connecting the work surface platform and the base, the height adjustment mechanism including:
- a set of pivot arms including a base pivot arm pivotably connected to the base and a platform pivot arm pivotably connected to the work surface platform, the base pivot arm pivotably connected to the platform pivot arm to provide a scissoring motion when raising and lowering the work surface platform to various heights;
- a first sliding mechanism on an end of the platform pivot arm between the end of the platform pivot arm and the base; and
- a second sliding mechanism on an end of the base pivot arm between the end of the base pivot arm and the work surface platform;
- a force applying mechanism attached to the height adjustment mechanism to provide a force to assist in elevation of the work surface platform,
- wherein the force applying mechanism is adjacent an underside of the work surface platform and extends between an underside of the work surface platform and the height adjustment mechanism along a direction generally parallel to a work surface of the work surface platform; and
- a locking device that holds the work surface platform at various heights above the base,
- wherein the locking device includes a handle that a user pulls on to unlock the locking device.
16. A desktop workspace that adjusts vertically, comprising:
- a work surface platform;
- a base configured to sit on an existing platform;
- a height adjustment mechanism connecting the work surface platform and the base, the height adjustment mechanism including:
- a set of pivot arms including a base pivot arm pivotably connected to the base and a platform pivot arm pivotably connected to the work surface platform, the base pivot arm pivotably connected to the platform pivot arm to provide a scissoring motion when raising and lowering the work surface platform to various heights;
- a first sliding mechanism on an end of the platform pivot arm between the end of the platform pivot arm and the base; and
- a second sliding mechanism on an end of the base pivot arm between the end of the base pivot arm and the work surface platform; and
- a force applying mechanism attached to the height adjustment mechanism to provide a force to assist in elevation of the work surface platform,
- wherein the force applying mechanism comprises a motorized linear actuator,

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wherein the force applying mechanism is adjacent an underside of the work surface platform and extends between an underside of the work surface platform and the height adjustment mechanism along a direction generally parallel to a work surface of the work surface platform.

17. A desktop workspace that adjusts vertically, comprising:

- a work surface platform;
  - a base configured to sit on an existing platform;
  - a height adjustment mechanism connecting the work surface platform and the base, the height adjustment mechanism including:
    - a set of pivot arms including a base pivot arm pivotably connected to the base and a platform pivot arm pivotably connected to the work surface platform, the base pivot arm pivotably connected to the platform pivot arm to provide a scissoring motion when raising and lowering the work surface platform to various heights;
    - a first sliding mechanism on an end of the platform pivot arm between the end of the platform pivot arm and the base; and
    - a second sliding mechanism on an end of the base pivot arm between the end of the base pivot arm and the work surface platform; and
  - a force applying mechanism attached to the height adjustment mechanism to provide a force to assist in elevation of the work surface platform,
- wherein the force applying mechanism comprises a motor,
- wherein the force applying mechanism is adjacent an underside of the work surface platform and extends between an underside of the work surface platform and the height adjustment mechanism along a direction generally parallel to a work surface of the work surface platform.

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18. A desktop workspace that adjusts vertically, comprising:

- a work surface platform;
  - a base configured to sit on an existing platform;
  - a height adjustment mechanism connecting the work surface platform and the base, the height adjustment mechanism including:
    - a set of pivot arms including a base pivot arm pivotably connected to the base and a platform pivot arm pivotably connected to the work surface platform, the base pivot arm pivotably connected to the platform pivot arm to provide a scissoring motion when raising and lowering the work surface platform to various heights;
    - a first sliding mechanism on an end of the platform pivot arm between the end of the platform pivot arm and the base; and
    - a second sliding mechanism on an end of the base pivot arm between the end of the base pivot arm and the work surface platform; and
  - a force applying mechanism attached to the height adjustment mechanism to provide a force to assist in elevation of the work surface platform,
- wherein the force applying mechanism is adjacent an underside of the work surface platform and extends between an underside of the work surface platform and the height adjustment mechanism along a direction generally parallel to a work surface of the work surface platform,
- wherein the force applying mechanism, the set of pivot arms, the base pivot arm connection to the base, and the platform pivot arm connection to the platform are positioned side-by-side when the desktop workspace is in a fully lowered position.

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